

SENSEI[†] first results, status and plans

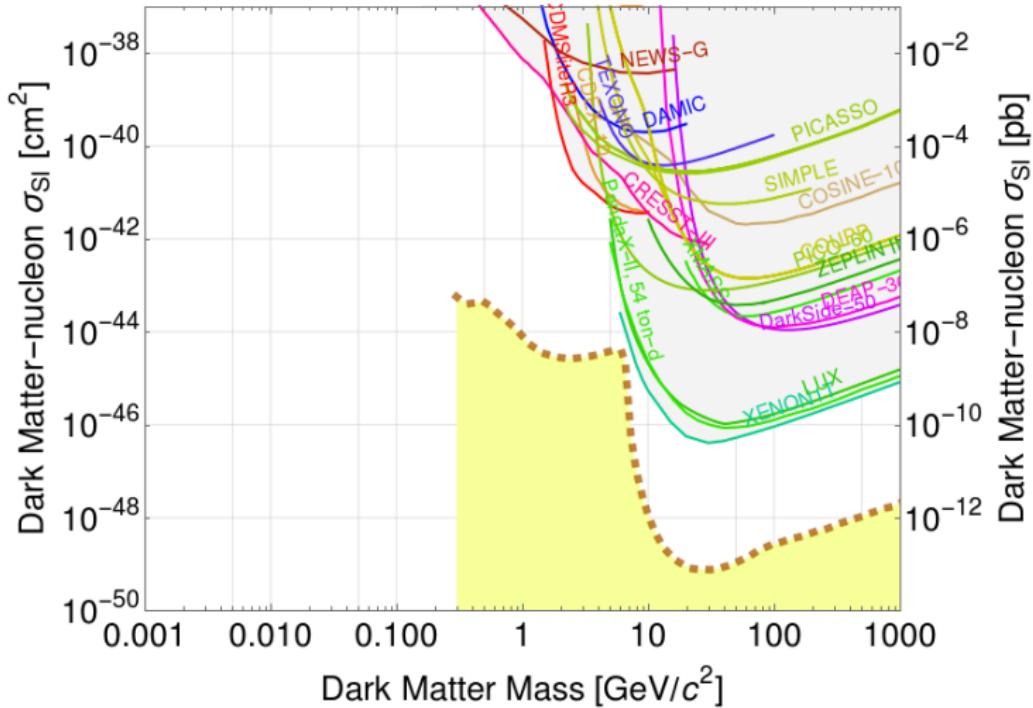
Javier Tiffenberg
for the SENSEI Collaboration

July 18, 2019

† Sub-Electron-Noise SkipperCCD Experimental Instrument

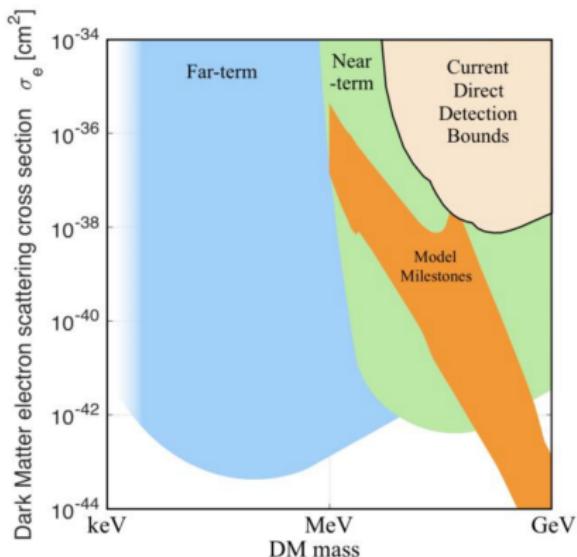


Context & Motivation: Direct detection history



Context & Motivation: community interest - new candidates

Single electron sensitivity opens several order of magnitude in mass and cross section for small projects.



DOE report for basic research needs for Dark Matter Science.

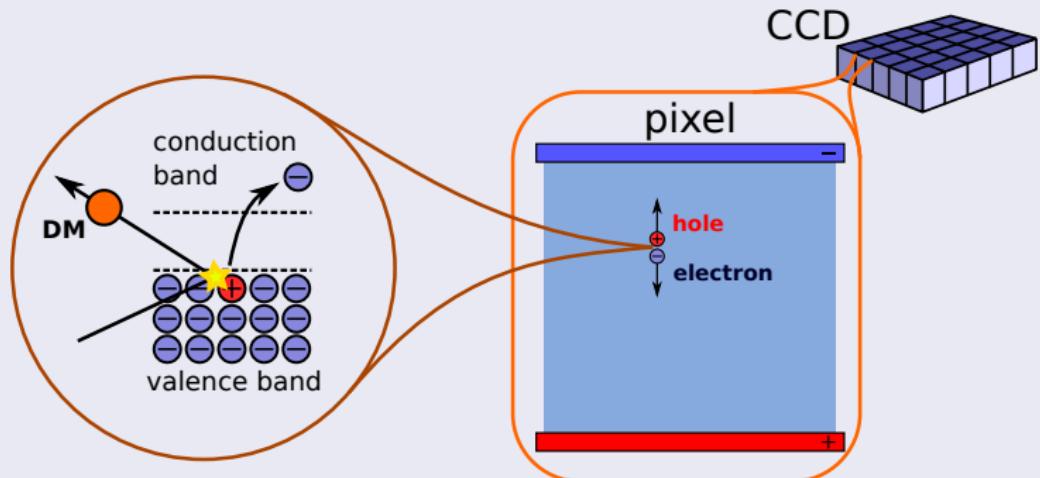
https://science.energy.gov/-/media/hep/pdf/Reports/Dark_Matter_New_Initiatives_rpt.pdf



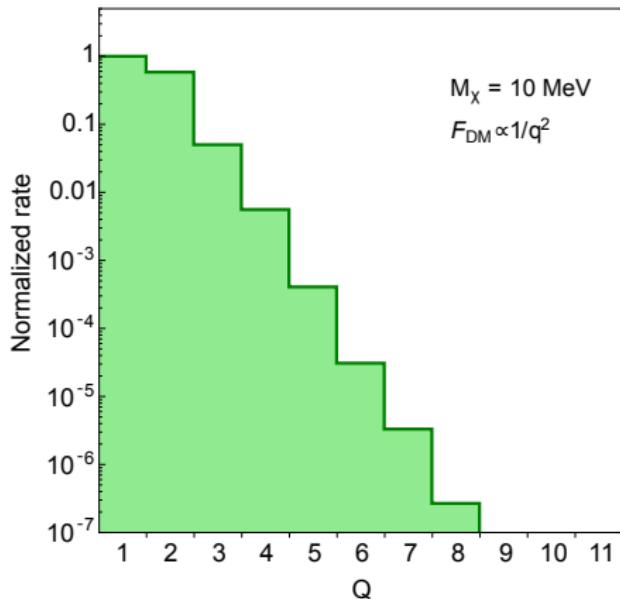
SENSEI: lower the energy threshold to look for light DM candidates

Detect DM-e interactions by measuring the ionization produced by the electron recoils. See arXiv:1509.01598

Idea: use electrons in the bulk silicon from a CCD as target



Typical e^- -recoil spectrum for benchmark models



- the sensitivity is limited by the lowest charge bin.
- background impact is reduced due to the small energy window.
- main background for semiconductors detectors is the **dark current**.

SENSEI: Sub-Electron-Noise SkipperCCD Experimental Instrument

SENSEI LDRD Collaboration (2015)

Develop a CCD-based detector with an energy threshold close to the silicon band gap (1.1 eV) using SkipperCCDs produced at LBL MSL

- **Fermilab:** Tiffenberg, Guardincerri, Sofo Haro
- **Stony Brook:** Rouven Essig
- **LBNL:** Steve Holland, Christopher Bebek
- **Tel Aviv University:** Tomer Volansky
- **University of Oregon:** Tien-Tien Yu
- **Stanford University*:** Jeremy Mardon

Successful completion of LDRD objectives (2017)

- Build the first working detector using Skipper-CCDs.
- Validate the technology for DM and ν experiments.
 - ▶ Probe DM masses at the MeV scale through electron recoil.
 - ▶ Probe axion and hidden-photon DM with masses down to 1 eV.



SENSEI Collaboration

Build a detector using Skipper-CCDs to search for light DM candidates



Stony Brook University



TEL AVIV UNIVERSITY



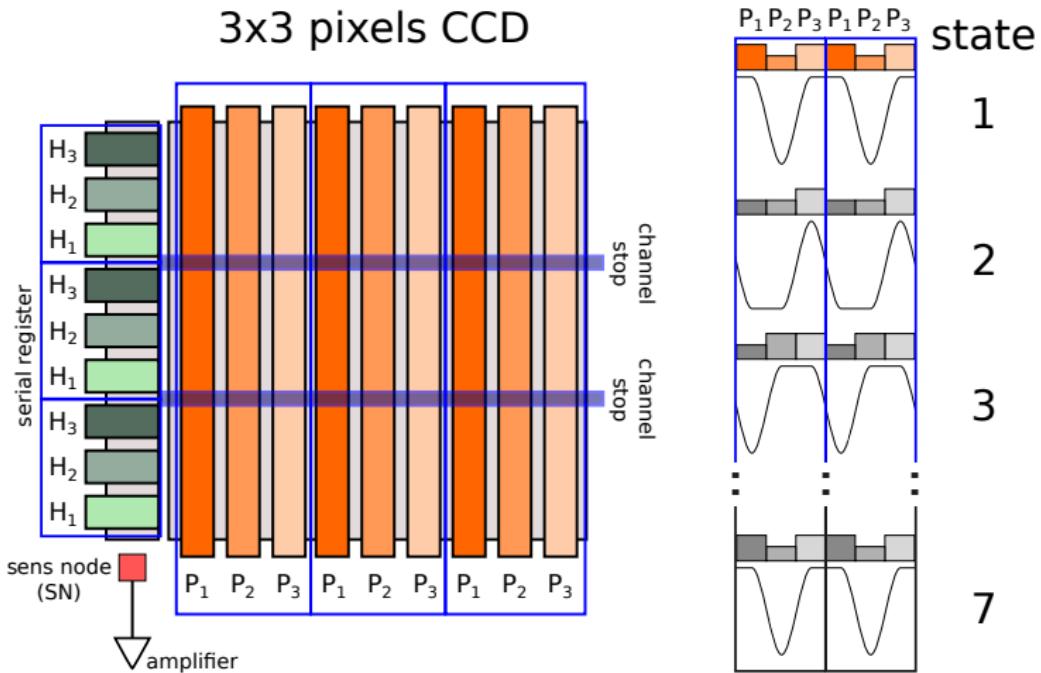
UNIVERSITY OF
OREGON

- **Fermilab:** Michael Crisler, Alex Drlica-Wagner, Juan Estrada, Guillermo Fernandez, Miguel Sofo Haro, Javier Tiffenberg
- **Oregon University:** Tien-Tien Yu
- **Stony Brook:** Rouven Essig
- **Tel Aviv University:** Liron Barack, Erez Ezion, Tomer Volansky
- + several additional students + more to come

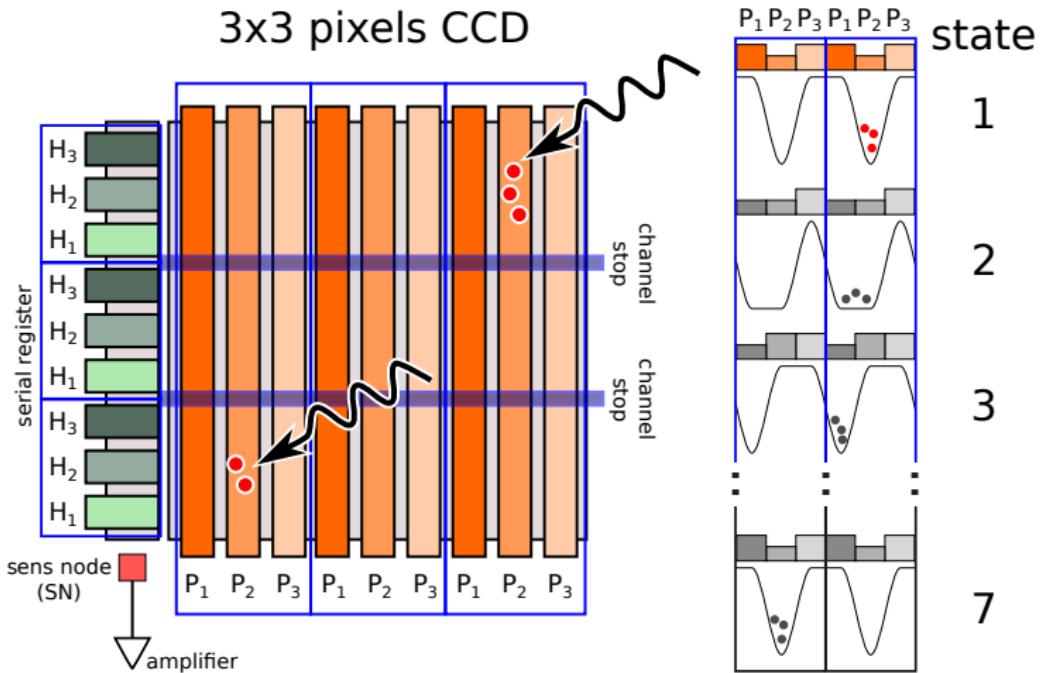
Fully funded by Heising-Simons Foundation & Fermilab



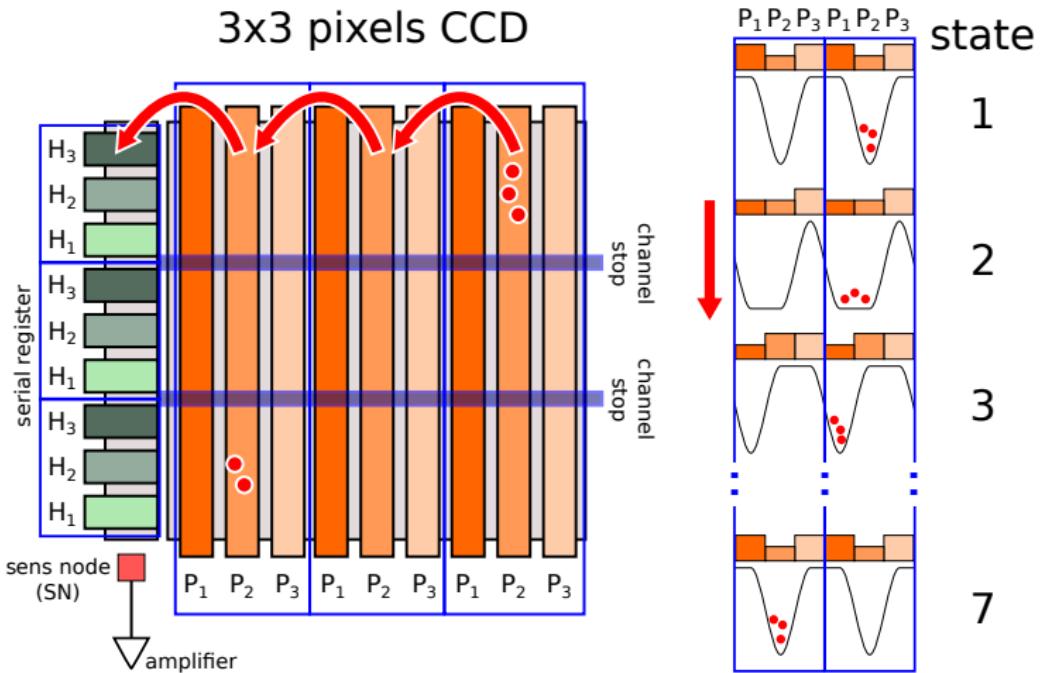
CCD: readout



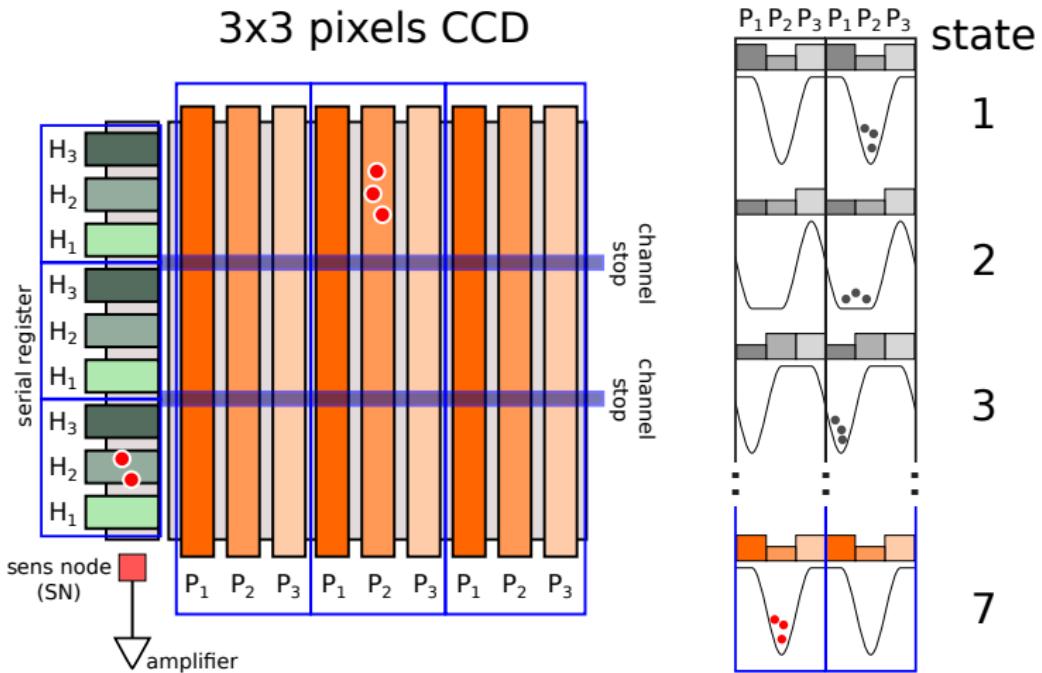
CCD: readout



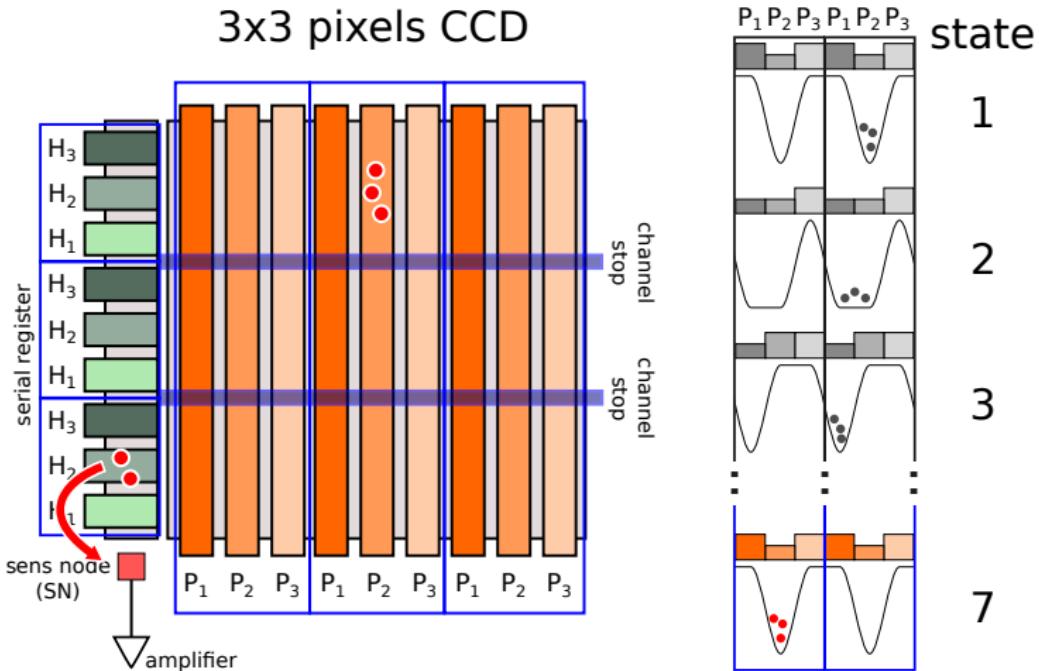
CCD: readout



CCD: readout

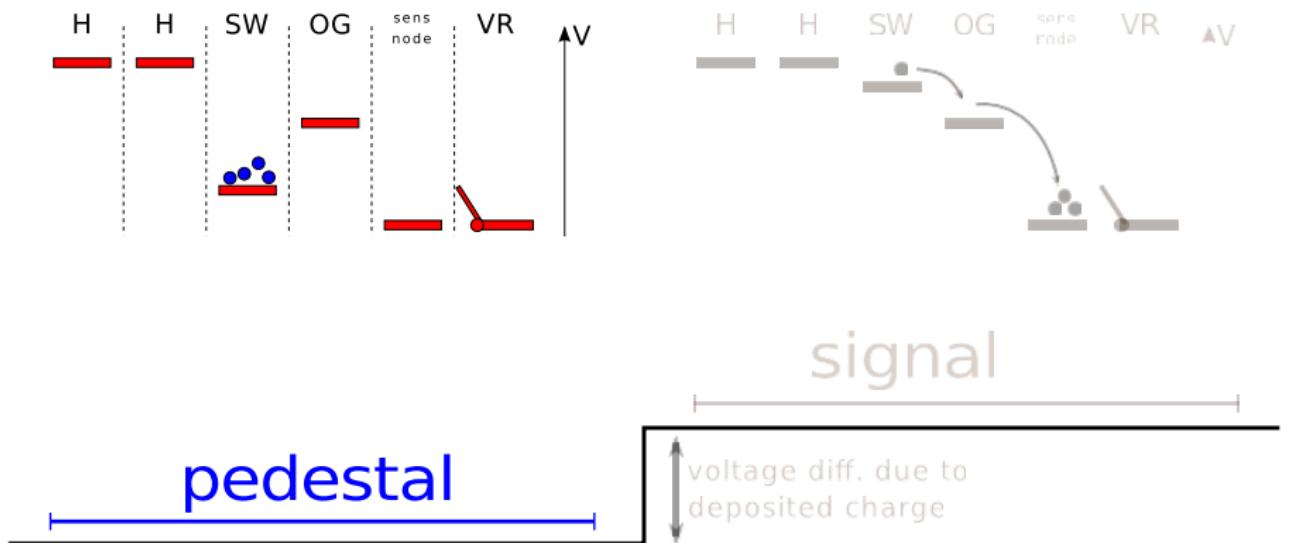


CCD: readout

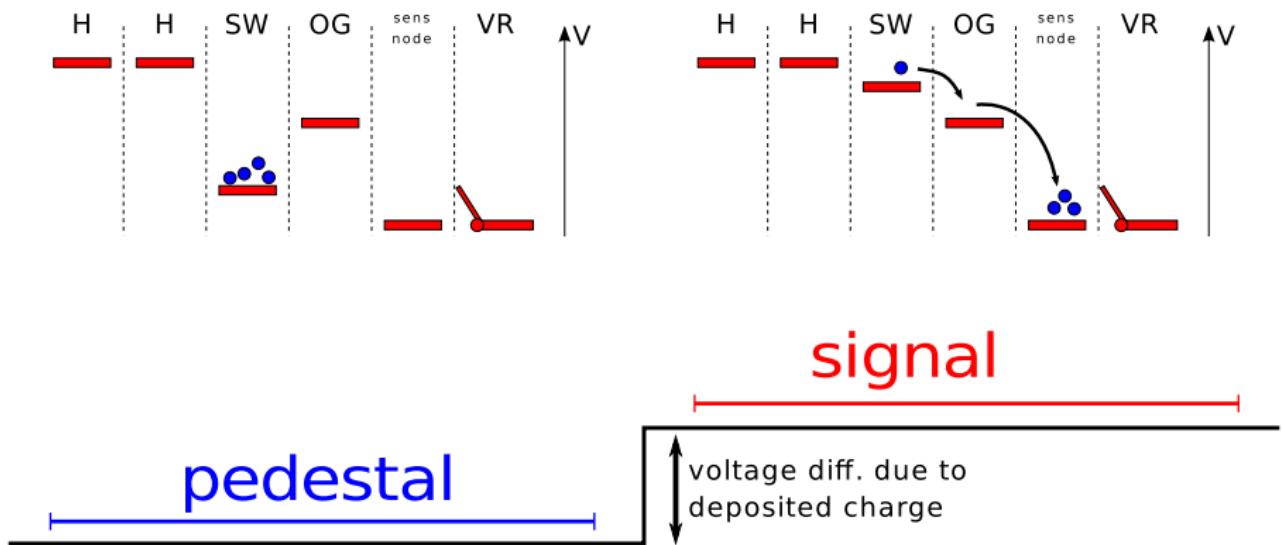


capacitance of the system is set by the SN: $C=0.05\text{pF} \rightarrow 3\mu\text{V}/\text{e}$

CCD: readout

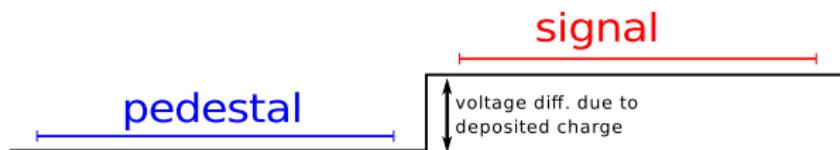


CCD: readout

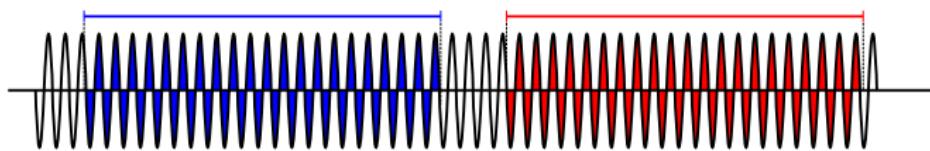


CCD: readout

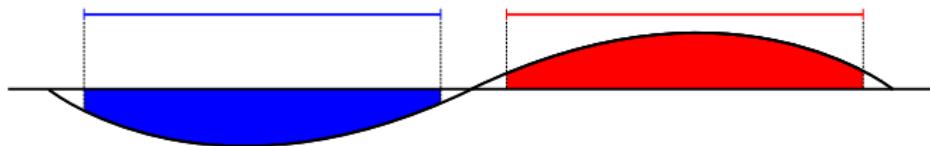
pixel charge measurement



high frequency noise

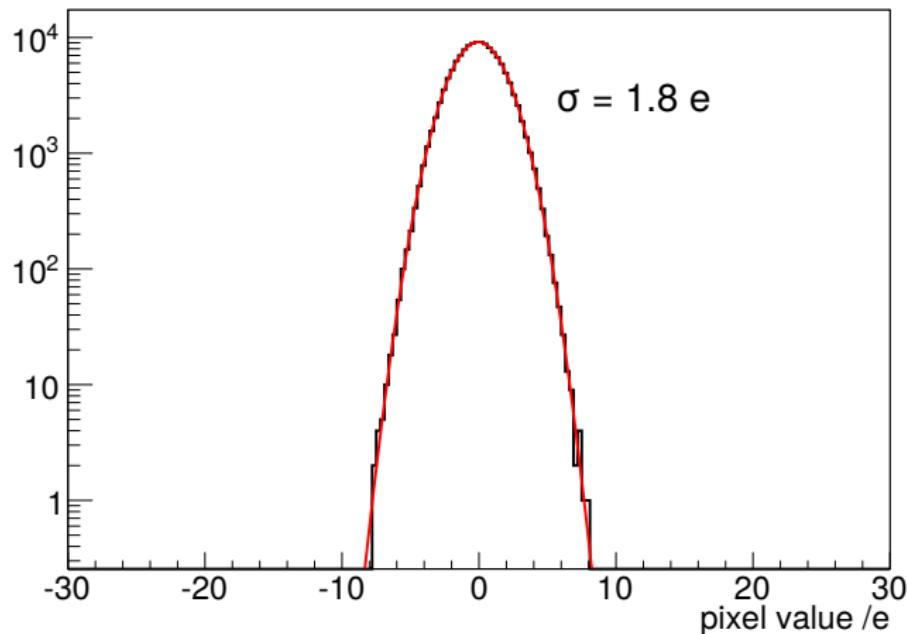


low frequency noise



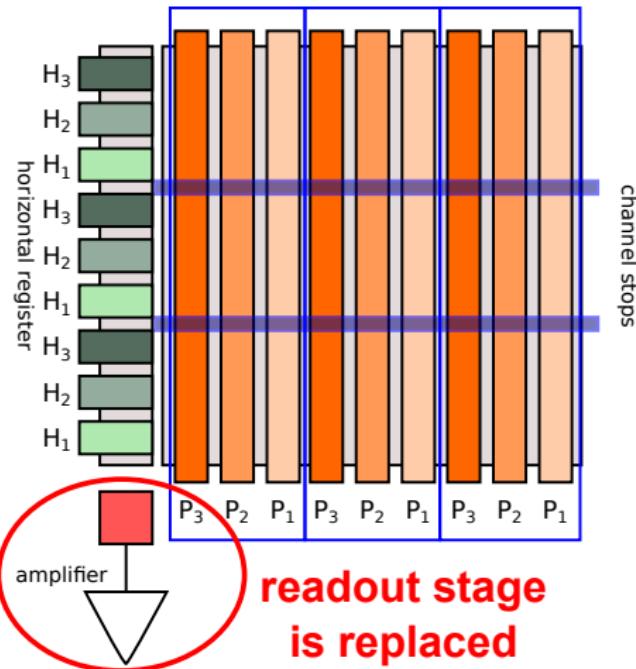
excellent for removing high frequency noise but sensitive to low frequencies

Readout noise: empty pixels distribution, regular scientific CCD



2 e^- readout noise roughly corresponds to 50 eV energy threshold

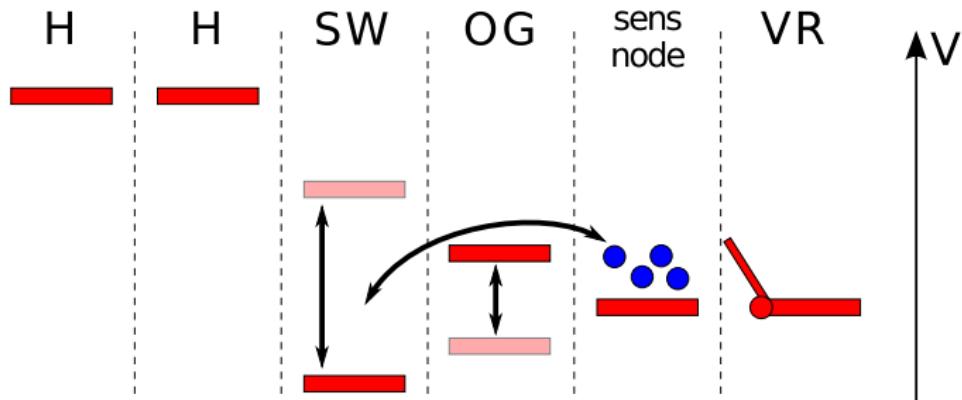
Lowering the noise: Skipper CCD



Only the readout stage is modified

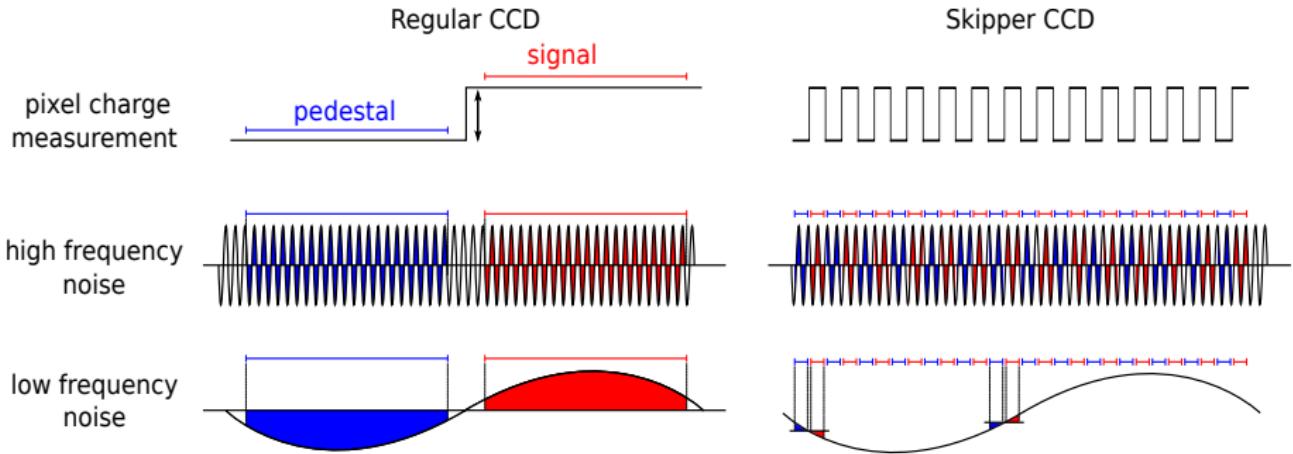
Lowering the noise: Skipper CCD

- **Main difference:** the Skipper CCD allows multiple sampling of the same pixel without corrupting the charge packet.
- The final pixel value is the average of the samples
$$\text{Pixel value} = \frac{1}{N} \sum_i^N (\text{pixel sample})_i$$
- Idea proposed in 1990 by Janesick et al. (doi:10.1117/12.19452)



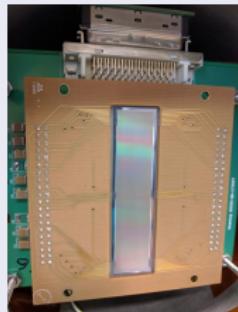
Lowering the noise: Skipper CCD

- **Main difference:** the Skipper CCD allows multiple sampling of the same pixel without corrupting the charge packet.
- The final pixel value is the average of the samples
$$\text{Pixel value} = \frac{1}{N} \sum_i^N (\text{pixel sample})_i$$
- Idea proposed in 1990 by Janesick et al. (doi:10.1117/12.19452)



SENSEI: First working instrument using SkipperCCD tech

Sensors



- Skipper-CCD prototype designed at LBL MSL
- 200 & 250 μm thick, 15 μm pixel size
- Two form factors $4\text{k}\times 1\text{k}$ (0.5gr) & $1.2\text{k}\times 0.7\text{k}$ pixels
- Parasitic run, optic coating and Si resistivity $\sim 10\text{k}\Omega$
- 4 amplifiers per CCD, three different RO stage designs

Instrument



- System integration done at Fermilab
- Custom cold electronics
- Modified DES electronics for read out
- Firmware and image processing software
- Optimization of operation parameters

Image taken with SENSEI: 4000 samples per pixel (processed)

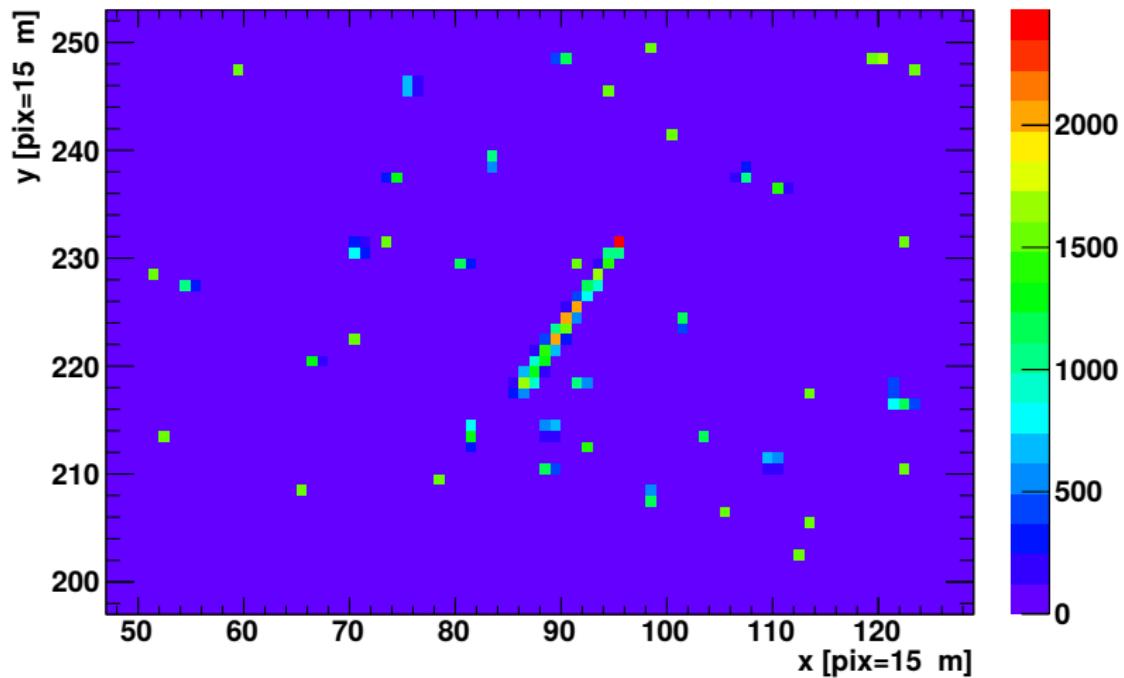


Image taken with SENSEI: 4000 samples per pixel (processed)

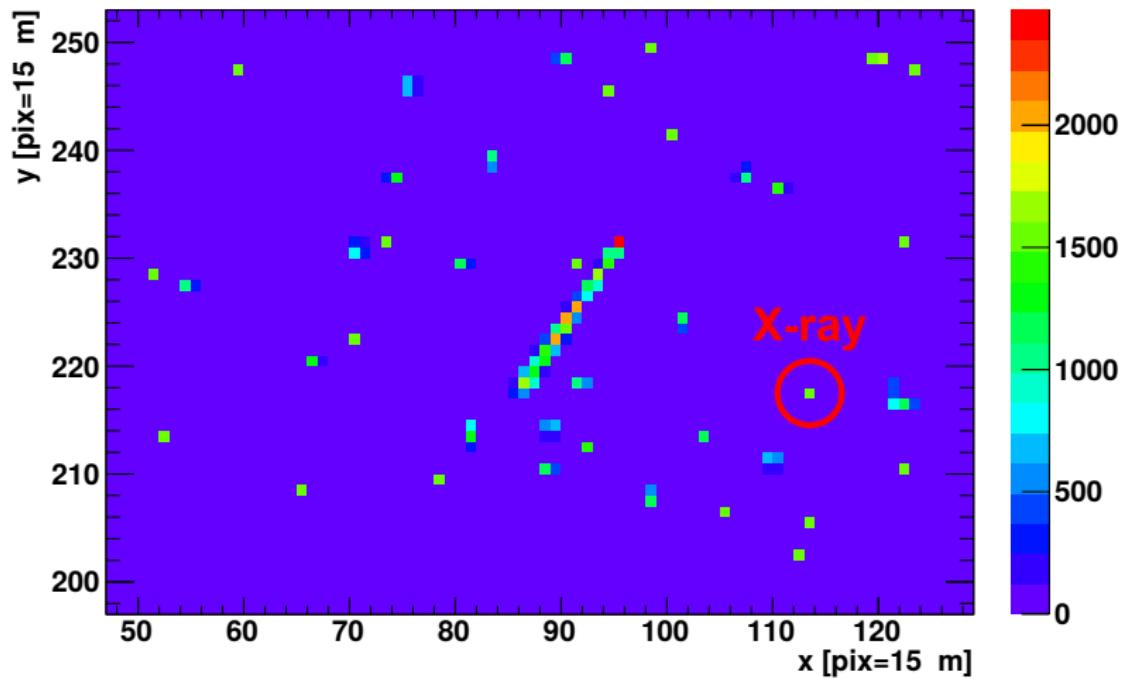


Image taken with SENSEI: 4000 samples per pixel (processed)

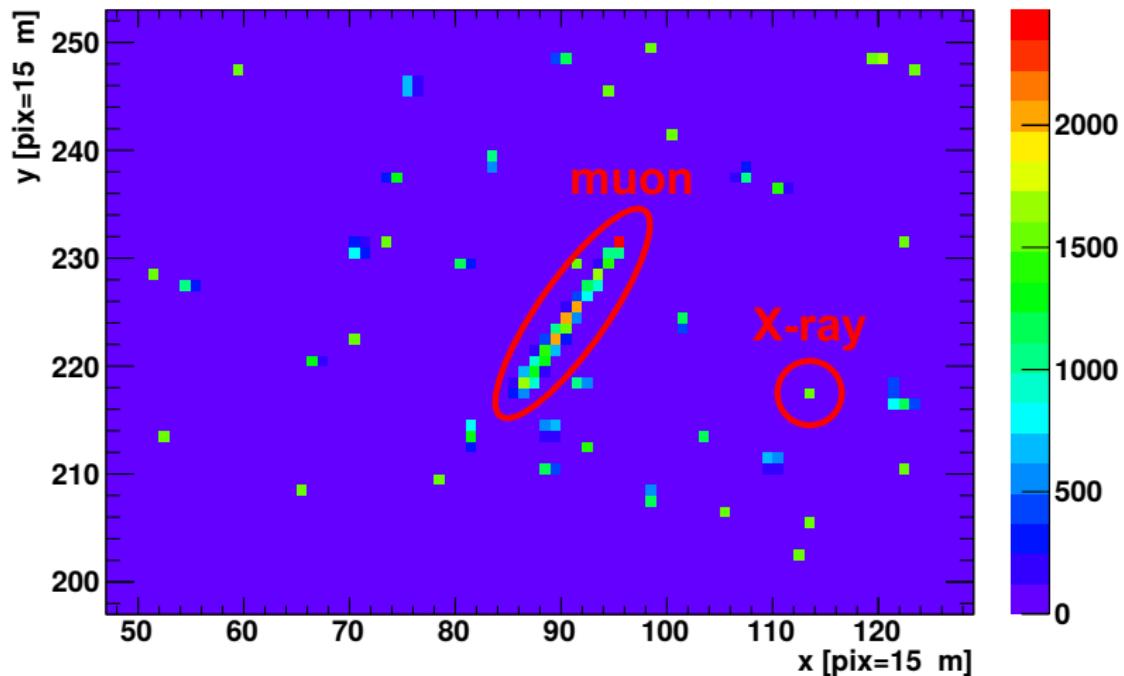
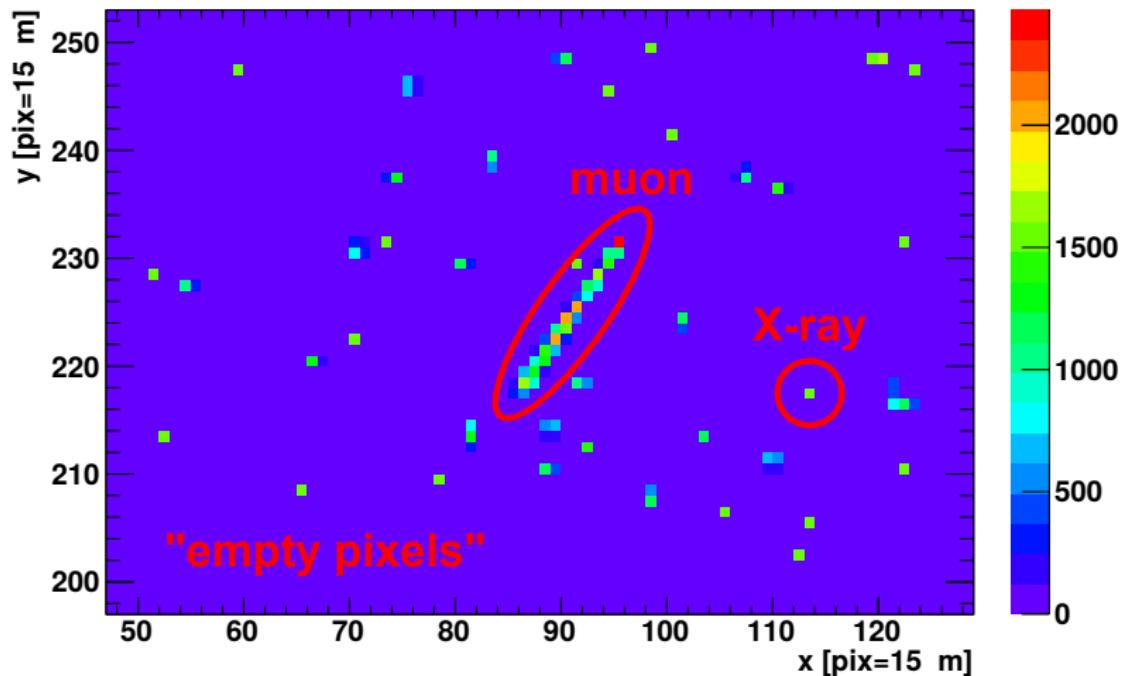
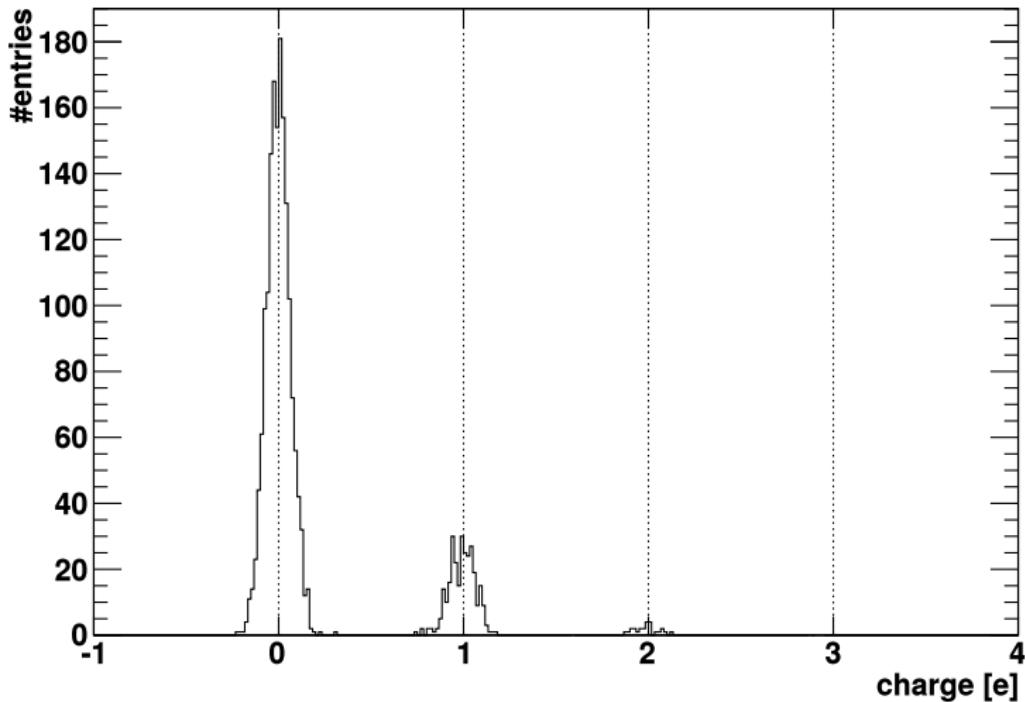


Image taken with SENSEI: 4000 samples per pixel (processed)

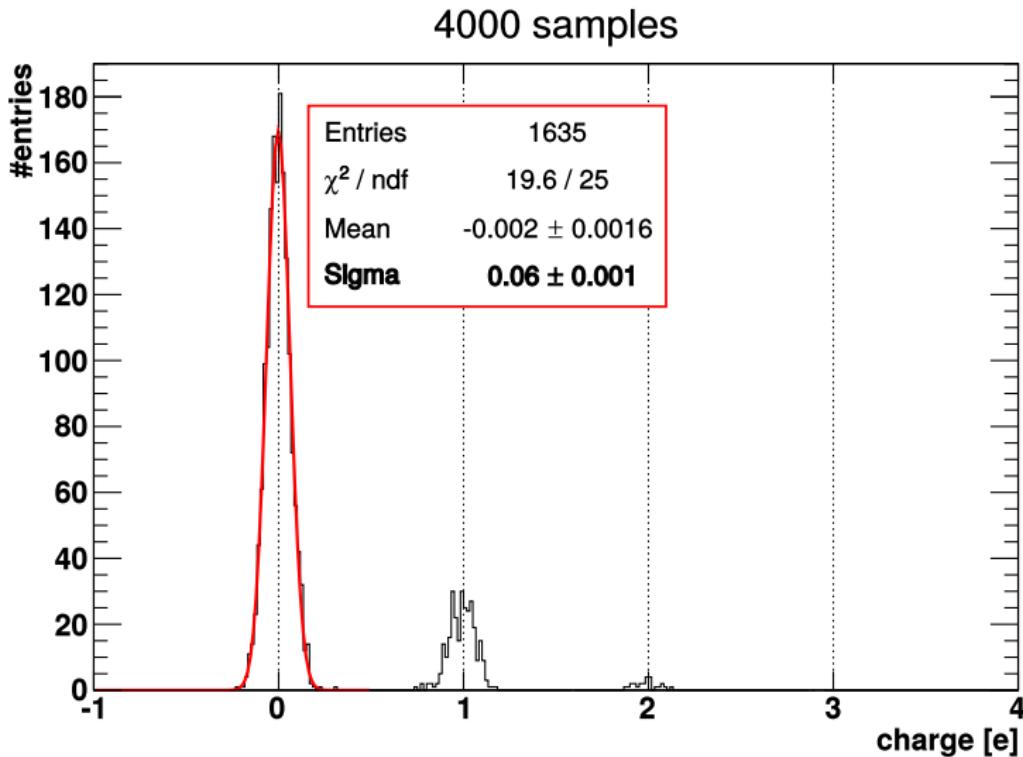


Charge in pixel distribution. Counting electrons: 0, 1, 2..

4000 samples

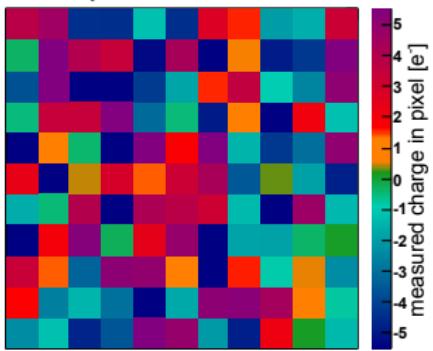


Charge in pixel distribution. Counting electrons: 0, 1, 2..

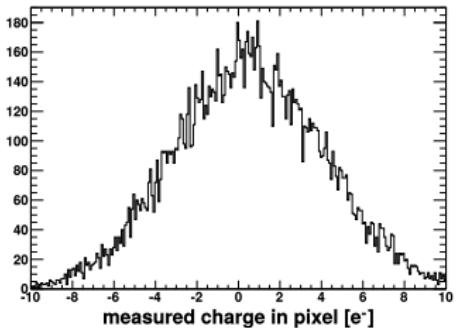


Counting electrons: 0, 1, 2..

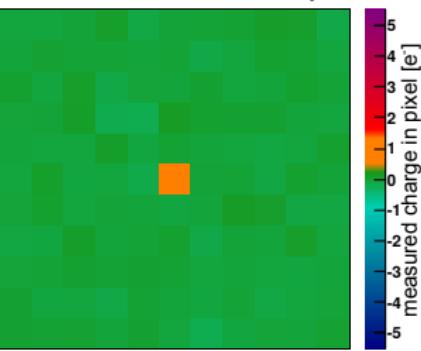
Standard CCD mode: charge in each pixel is measured once



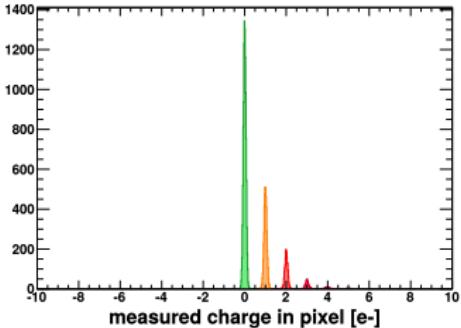
Readout-noise: 3.5 e RMS



New Skipper CCD: charge in each pixel is measured multiple times

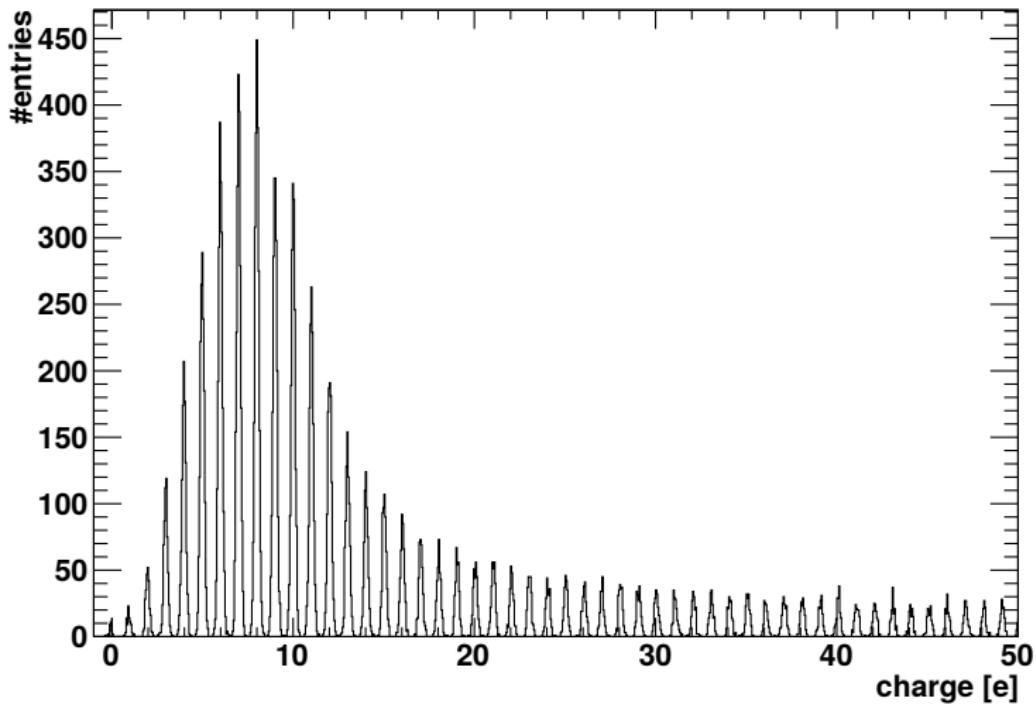


Readout-noise: 0.06 e RMS



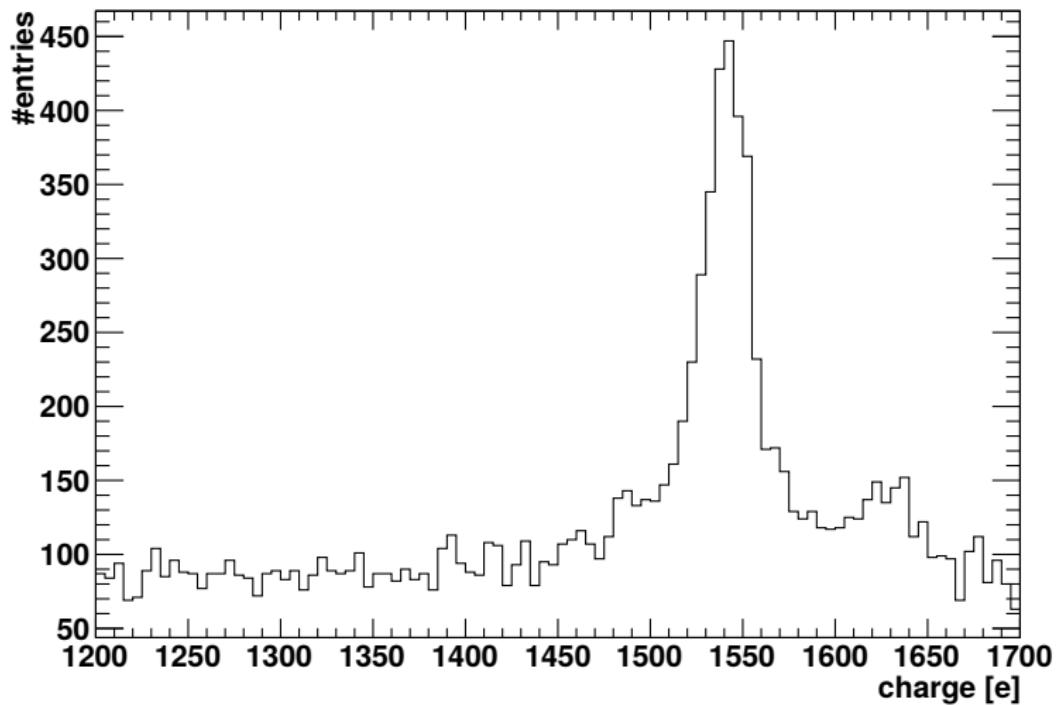
Counting electrons: ..48, 49, 50..

4000 samples

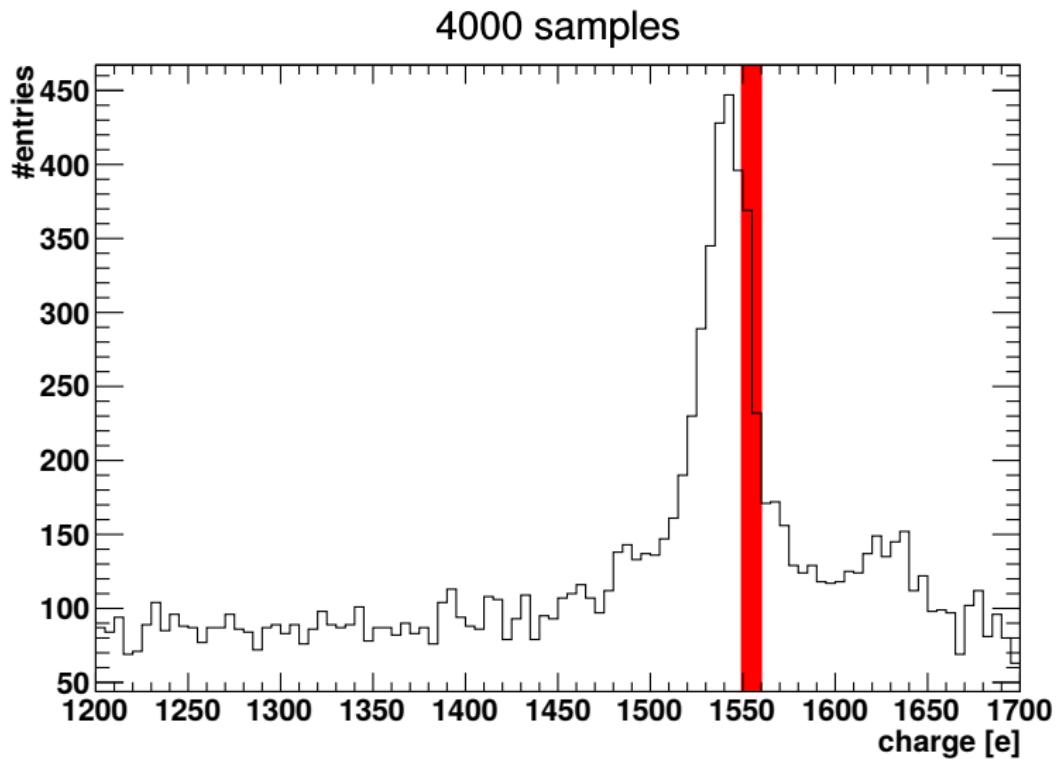


^{55}Fe X-ray source

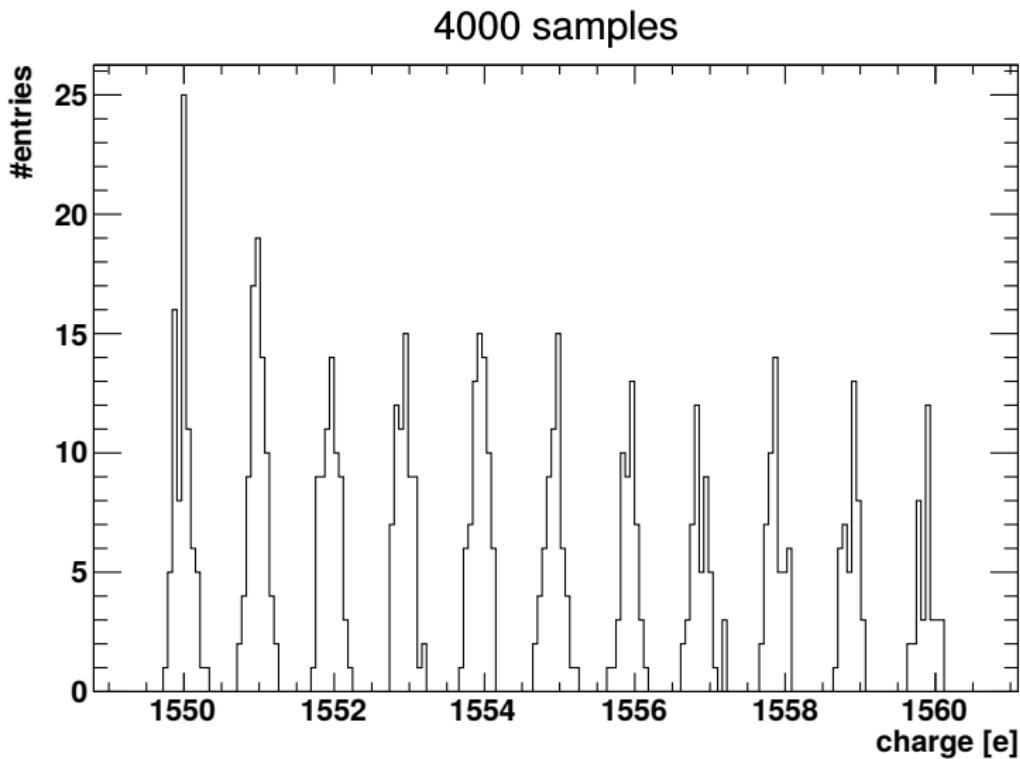
4000 samples



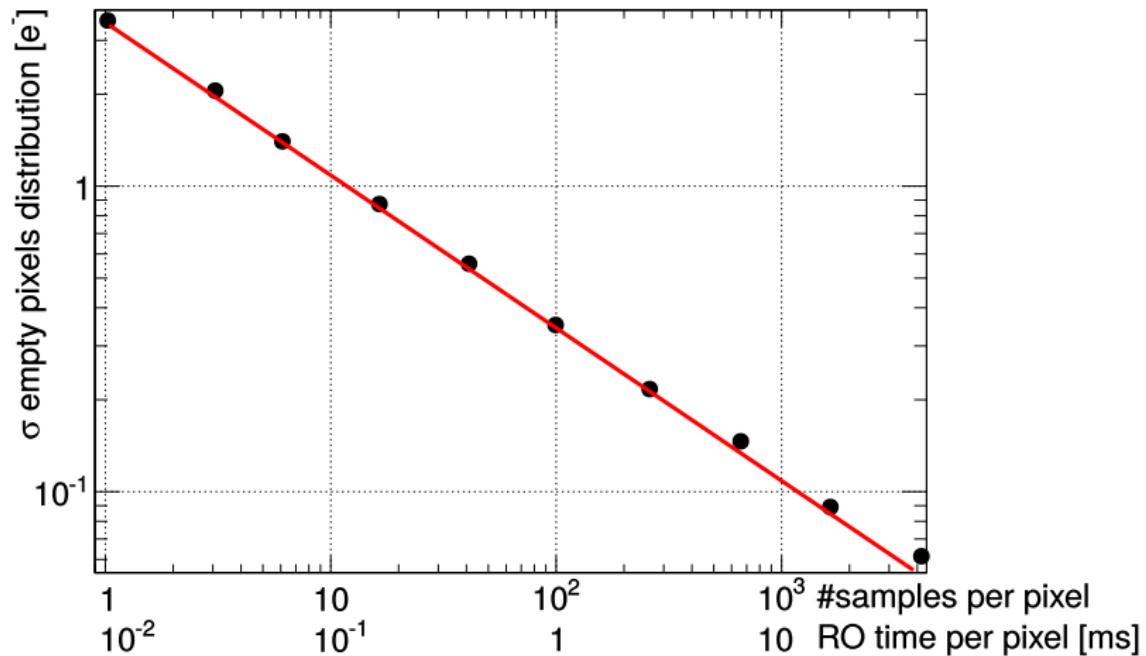
^{55}Fe X-ray source



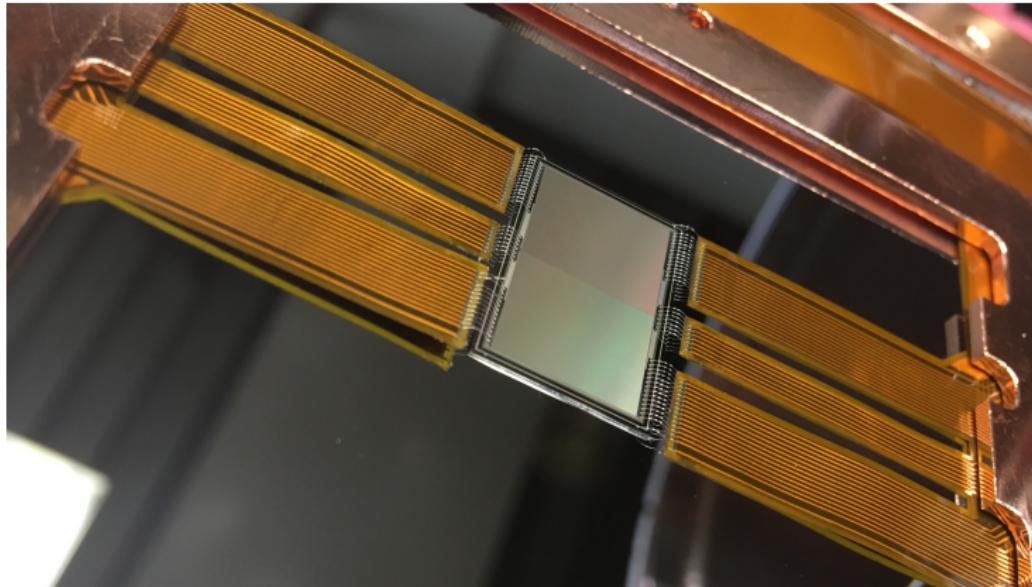
keep counting: ..1550, 1551, 1552..



Noise vs. #samples - $1/\sqrt{N}$

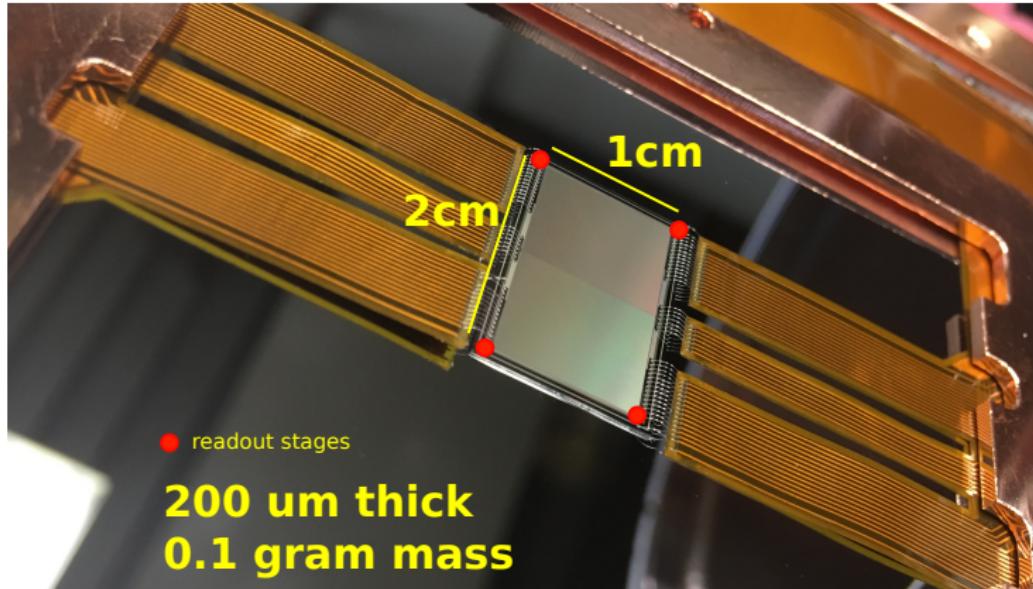


protoSENSEI: technology demonstrator



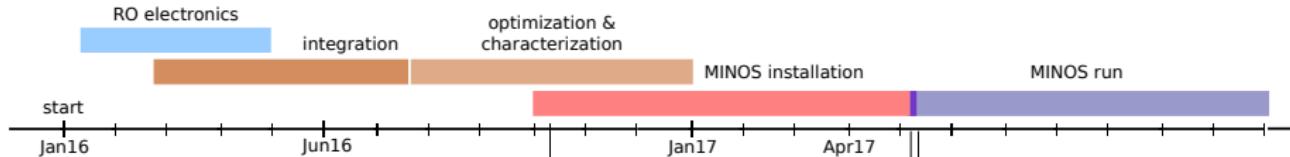
We used the parasitically-fabricated R&D sensors to learn how to optimize operations and produce early-science results

protoSENSEI: technology demonstrator



We used the parasitically-fabricated R&D sensors to learn how to optimize operations and produce early-science results

protoSENSEI: project timeline



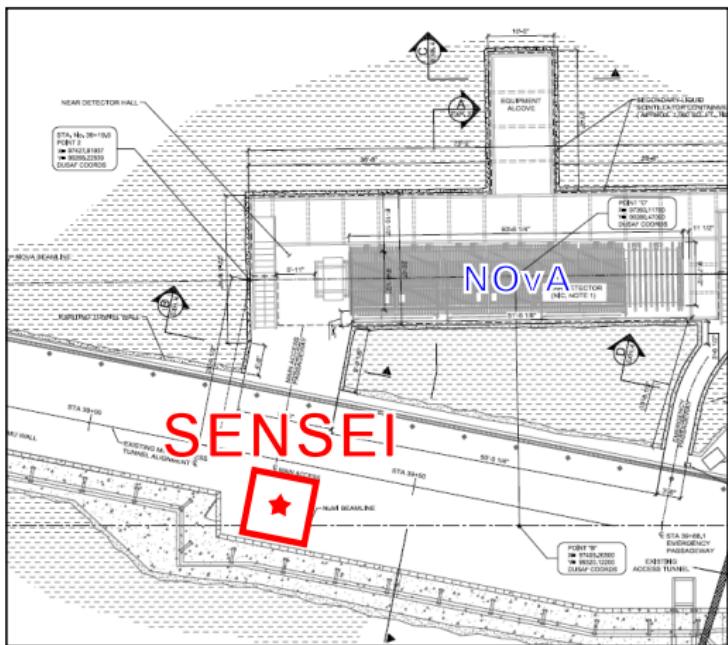
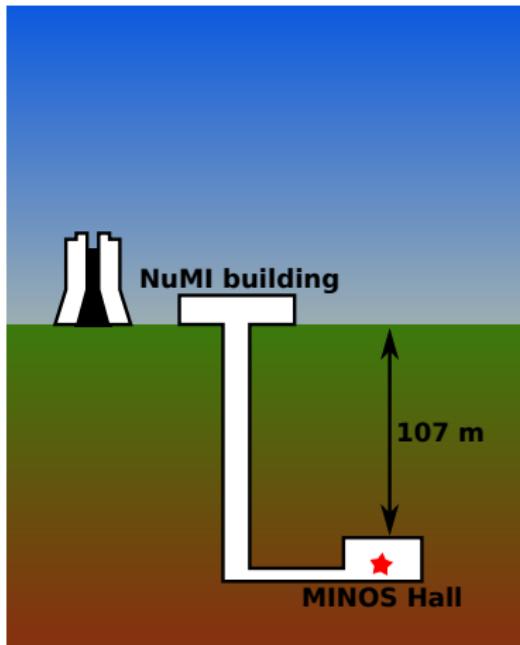
explore high xsec
arXiv:1804.00088



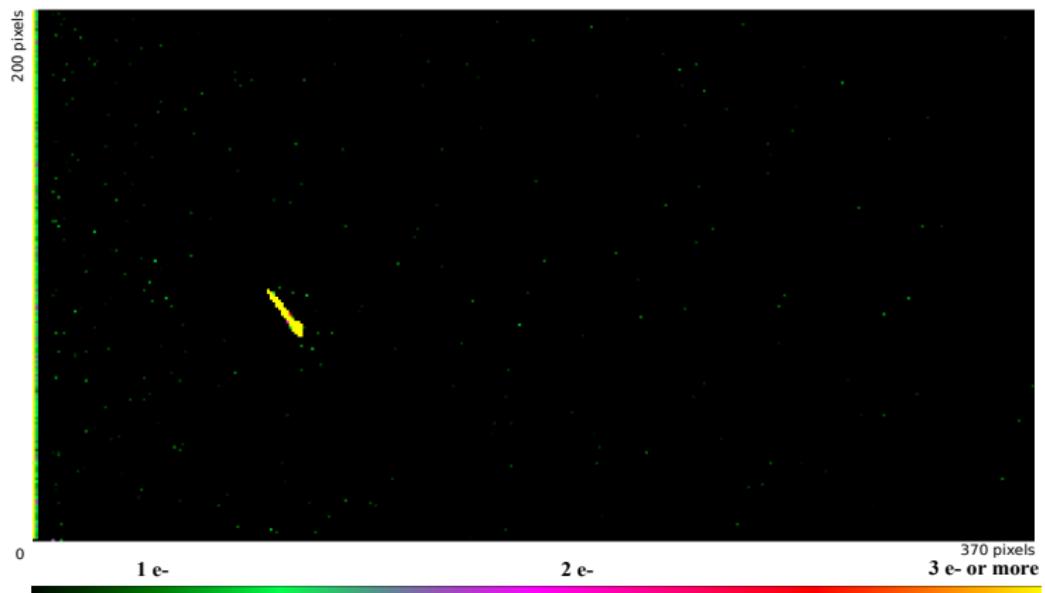
explore small xsec
arXiv:1901.10478

Current step: Prototype running @MINOS

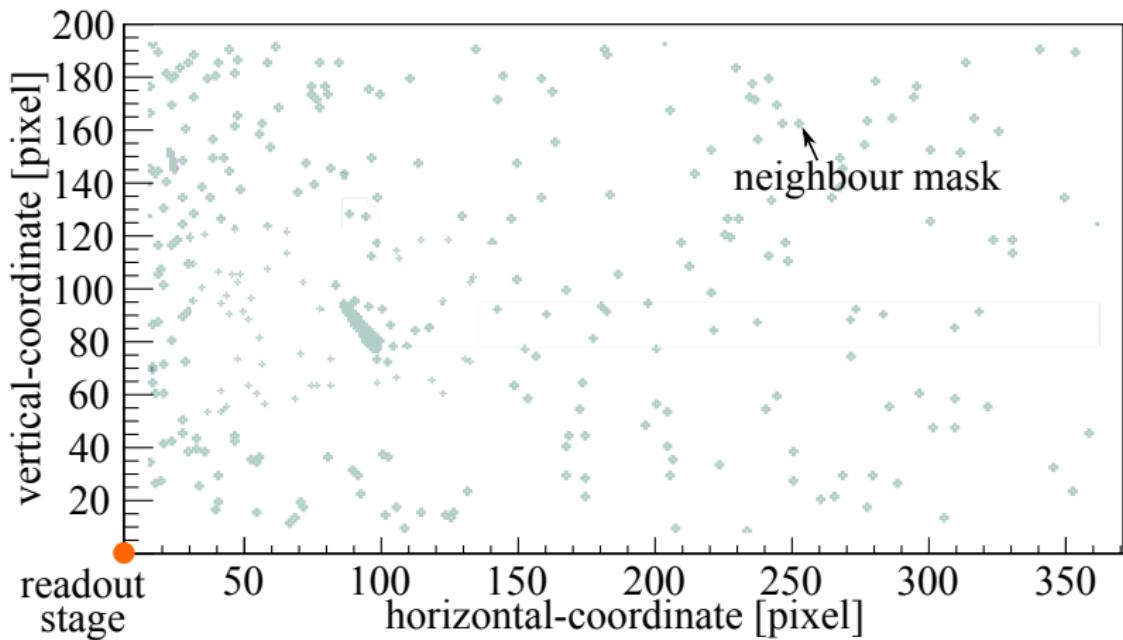
Technology demonstration: installation at shallow underground site



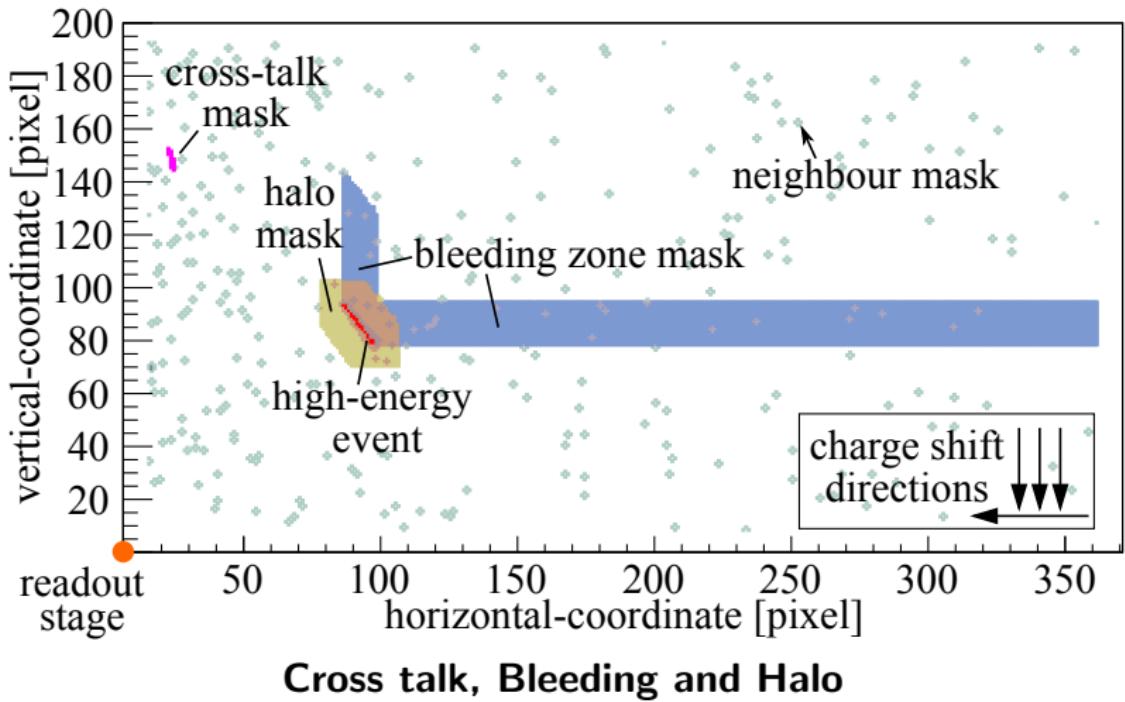
protoSENSEI @MINOS: raw image/data (70 min exposure)

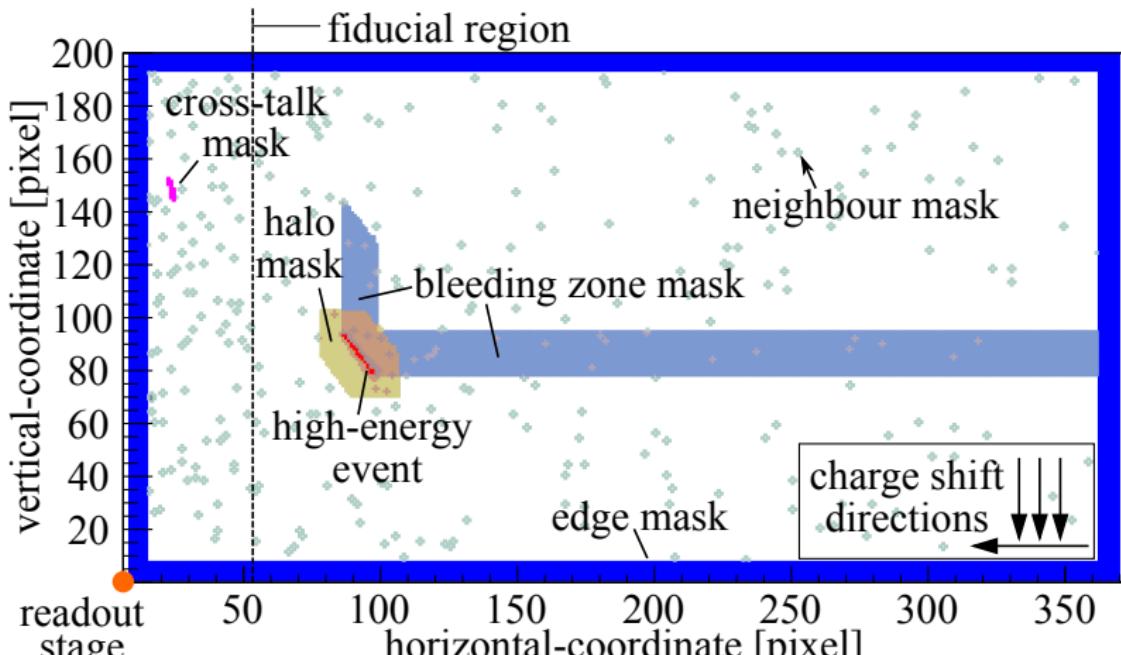


adjacent pixels with one or more electrons are grouped together



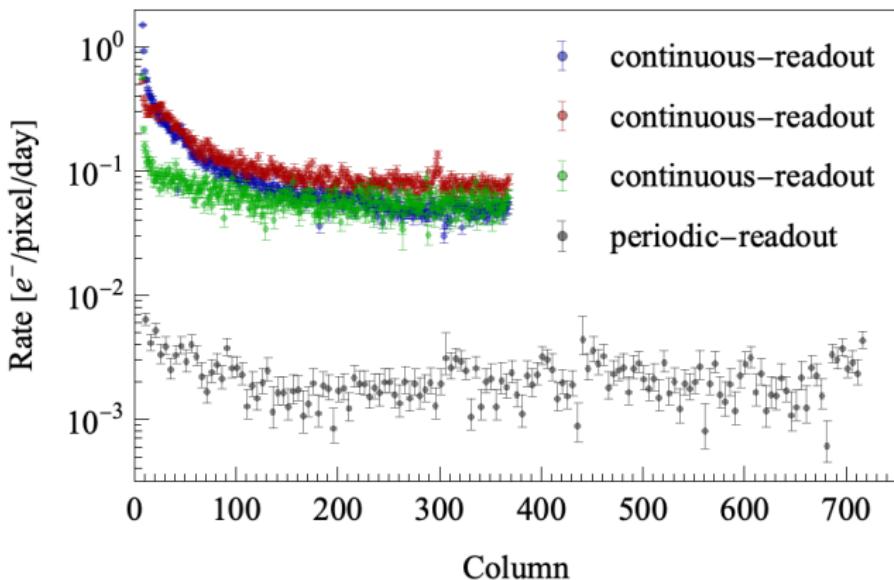
adjacent pixels with one or more electrons are grouped together





Edges and column dependence.

Column dependence may point to different readout scheme



protoSENSEI @MINOS: efficiency and exposure

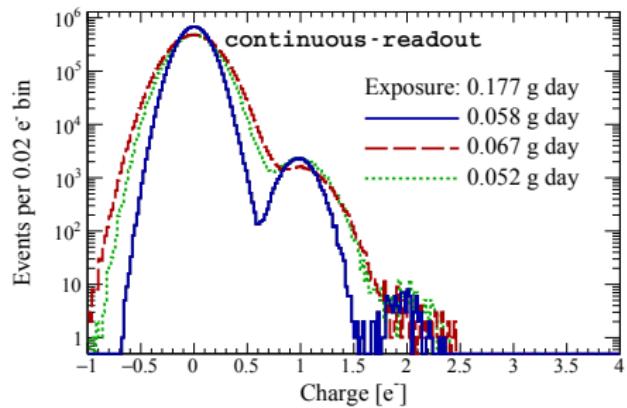
Cuts N _e	periodic			continuous		
	1	2	3	3	4	5
1. DM in single pixel	1	0.62	0.48	0.48	0.41	0.36
2. Nearest Neighbour		0.92			0.96	
3. Electronic Noise		1			~1	
4. Edge		0.92			0.88	
5. Bleeding		0.71			0.98	
6. Halo		0.80			0.99	
7. Cross-talk		0.99			~1	
8. Bad columns		0.80			0.94	
Total Efficiency	0.38	0.24	0.18	0.37	0.31	0.28
Eff. Expo. [g day]	0.069	0.043	0.033	0.085	0.073	0.064
Number of events	2353	21	0	0	0	0

protoSENSEI @MINOS: all the information, pick your model

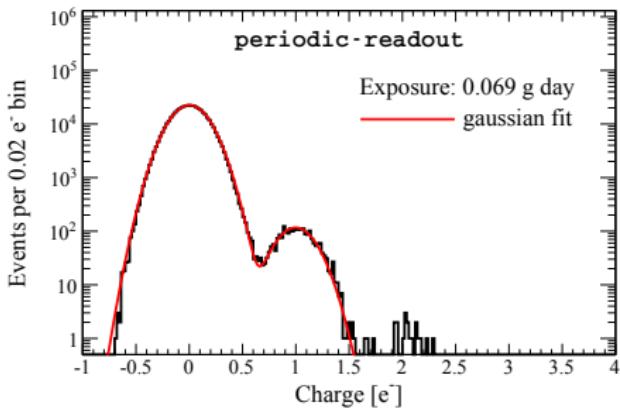
Cuts \ N_e	periodic			continuous		
	1	2	3	3	4	5
1. DM in single pixel	1	0.62	0.48	0.48	0.41	0.36
2. Nearest Neighbour		0.92			0.96	
3. Electronic Noise		1			~1	
4. Edge		0.92			0.88	
5. Bleeding		0.71			0.98	
6. Halo		0.80			0.99	
7. Cross-talk		0.99			~1	
8. Bad columns		0.80			0.94	
Total Efficiency	0.38	0.24	0.18	0.37	0.31	0.28
Eff. Expo. [g day]	0.069	0.043	0.033	0.085	0.073	0.064
Number of events	2353	21	0	0	0	0



Continuous readout

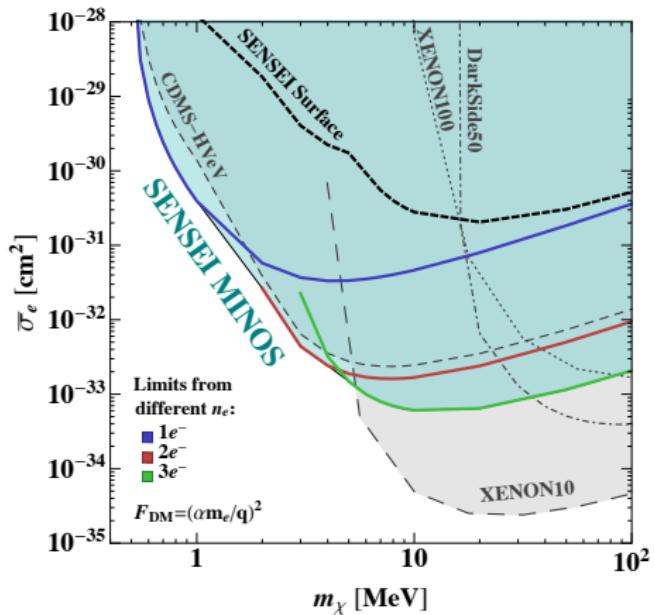


Periodic readout

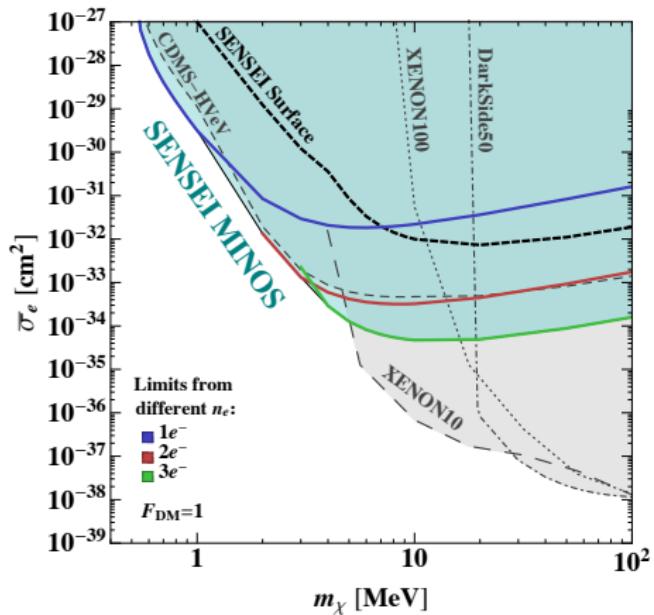


- No events with $3e^-$ or more
- Seems to follow a Poisson distribution. Still under studies.

Light Dark Photon



Heavy Dark Photon



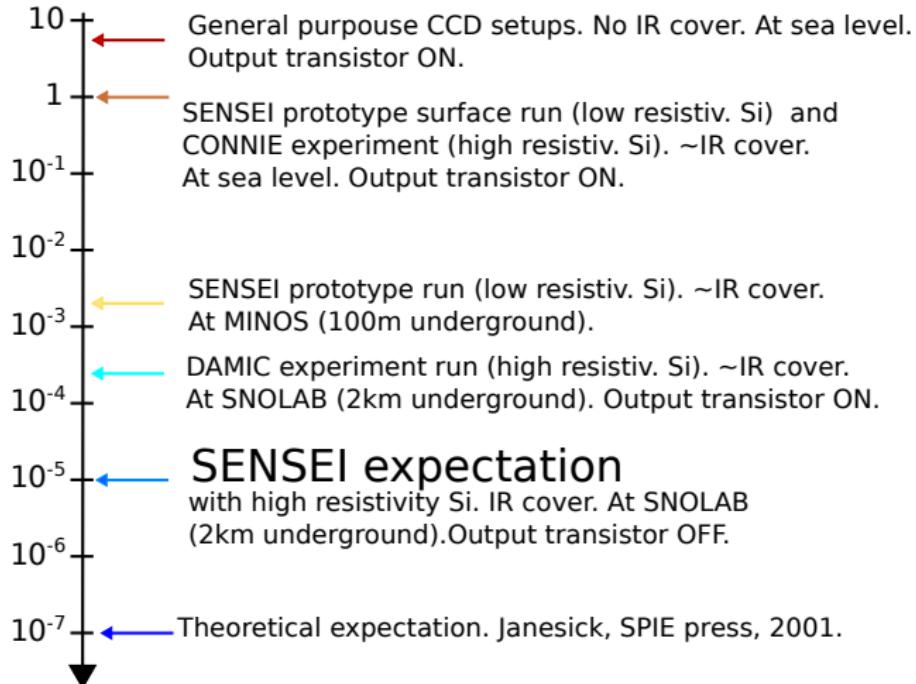
World best limit below 5 MeV!!

What are the next steps for SENSEI?

- 10 gram Skipper CCD system in 2019.
- 100-gram Skipper CCD system in 2020.

**we know how to build hundred-grams CCD systems
(DAMIC, CONNIE).**

DC (e-/pix/day)



SENSEI threshold vs dark current

- Counting electrons \Rightarrow **noise has zero impact**
- It can take about 1h to read the sensors
- **Dark Current is the limiting factor**

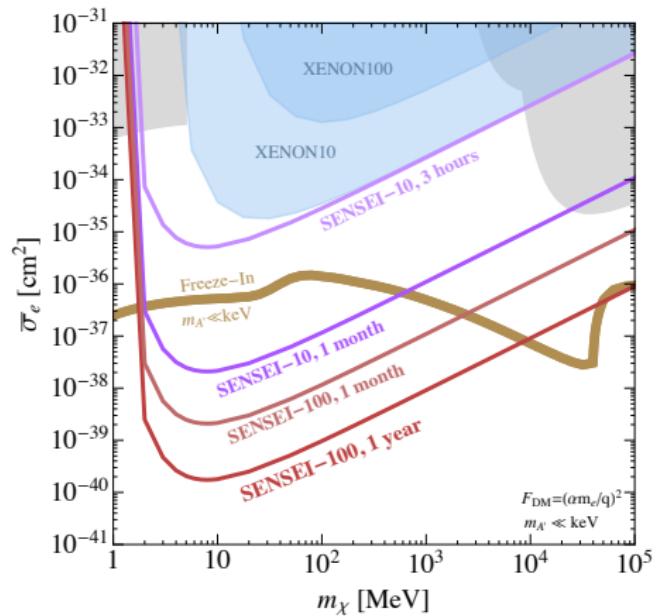
It's better to readout continuously to minimize the impact of the DC

Dark Current $[e^{-} \text{pix}^{-1} \text{day}^{-1}]$	$\geq 1e^{-}$ [pix]	$\geq 2e^{-}$ [pix]	$\geq 3e^{-}$ [pix]
10^{-3}	1×10^8	3×10^3	7×10^{-2}
10^{-5}	1×10^6	3×10^{-1}	7×10^{-8}
10^{-7}	1×10^4	3×10^{-5}	7×10^{-14}

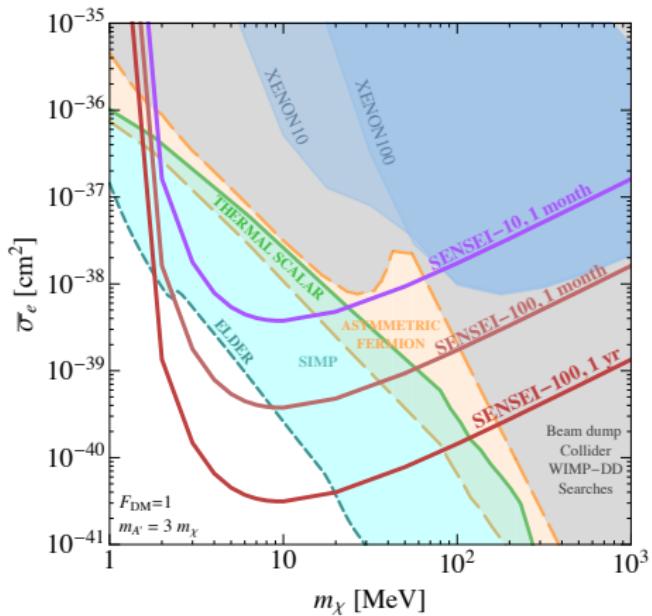
Operation mode (continuous-RO or long-exposures) will depend on the measured DC and spurious charge of the Science sensors

SENSEI: reach of a 100g, zeroish-background experiment

Light Dark Photon

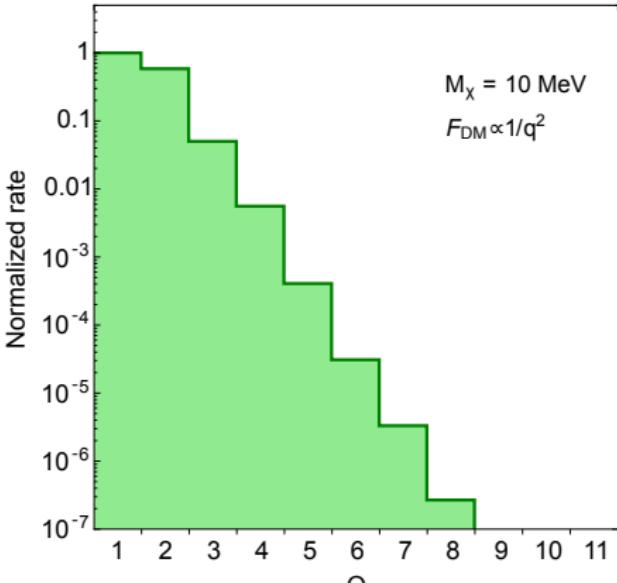
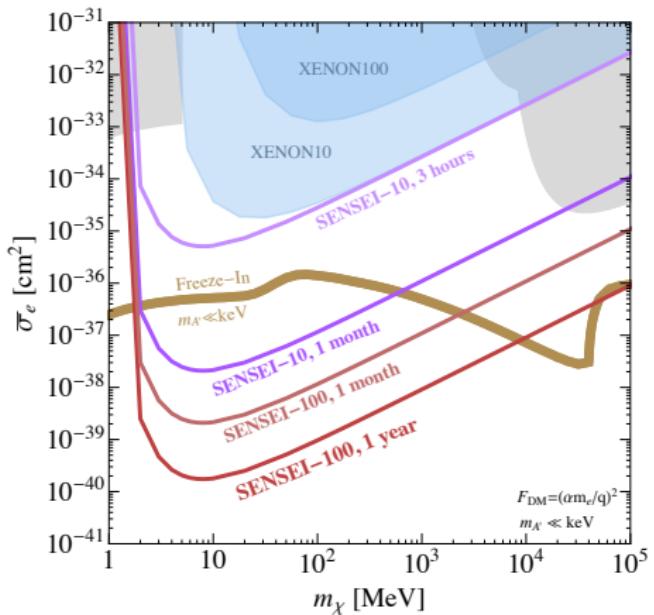


Heavy Dark Photon



SENSEI: electron recoil background requirements

The sensitivity is dominated by the lowest energy/charge bin



SENSEI: electron recoil background requirements

Back of the envelope calculation

A 100g detector that takes data for one year → **Expo = 36.5kg · day**

Assuming same background as in DAMIC:

- **5 DRU** (events·kg⁻¹·day⁻¹·keV⁻¹) in the 0-1keV range
→ $N_{\text{bkg}} = 36.5 \text{ kg} \cdot \text{day} \times 5 \text{ DRU} = 182.5 \text{ events}$
- Dominated by external gammas → flat Compton spectrum

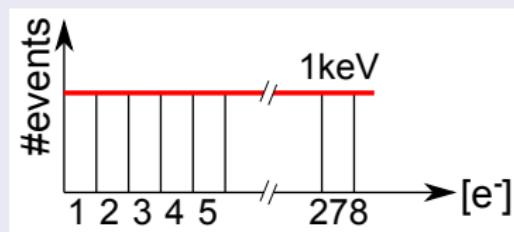
SENSEI: electron recoil background requirements

Back of the envelope calculation

A 100g detector that takes data for one year → **Expo = 36.5 kg · day**

Assuming same background as in DAMIC:

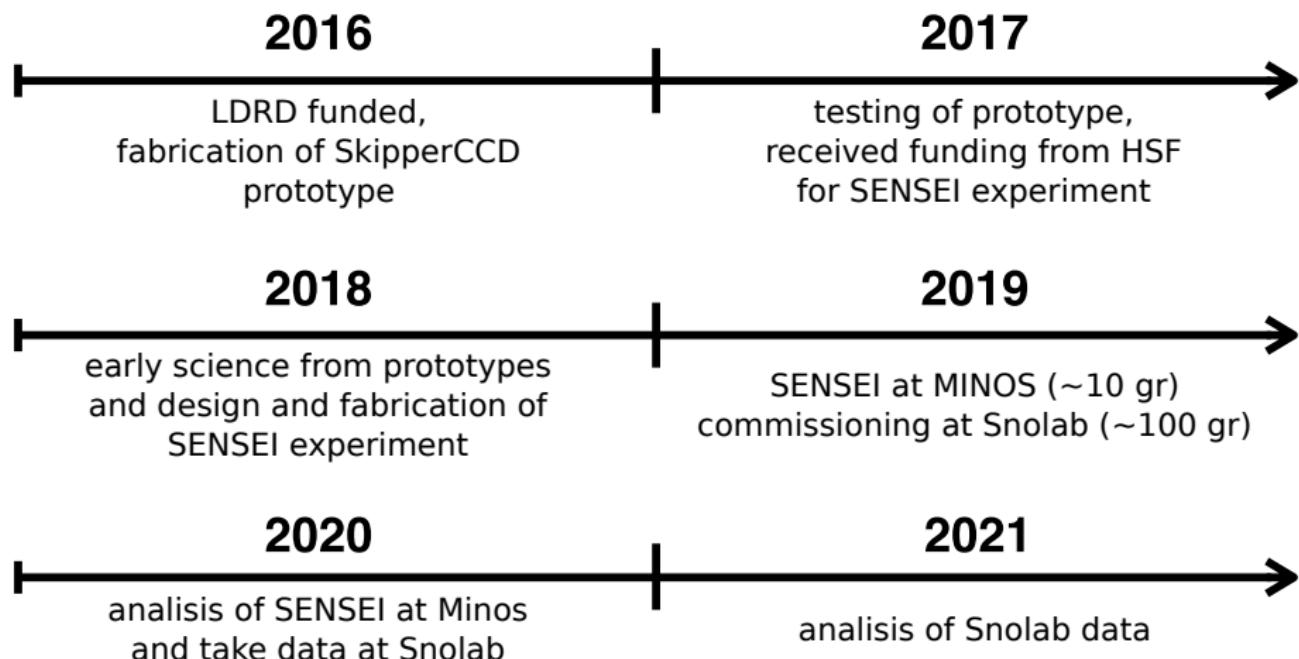
- **5 DRU** (events·kg⁻¹·day⁻¹·keV⁻¹) in the 0-1keV range
→ $N_{\text{bkg}} = 36.5 \text{ kg} \cdot \text{day} \times 5 \text{ DRU} = 182.5 \text{ events}$
- Dominated by external gammas → **flat Compton spectrum**



182.5 events over the 278 charge bins in the 0-1keV range

Expect 0.65 bkd events in the lowest (2 e⁻) charge-bin

Timeline

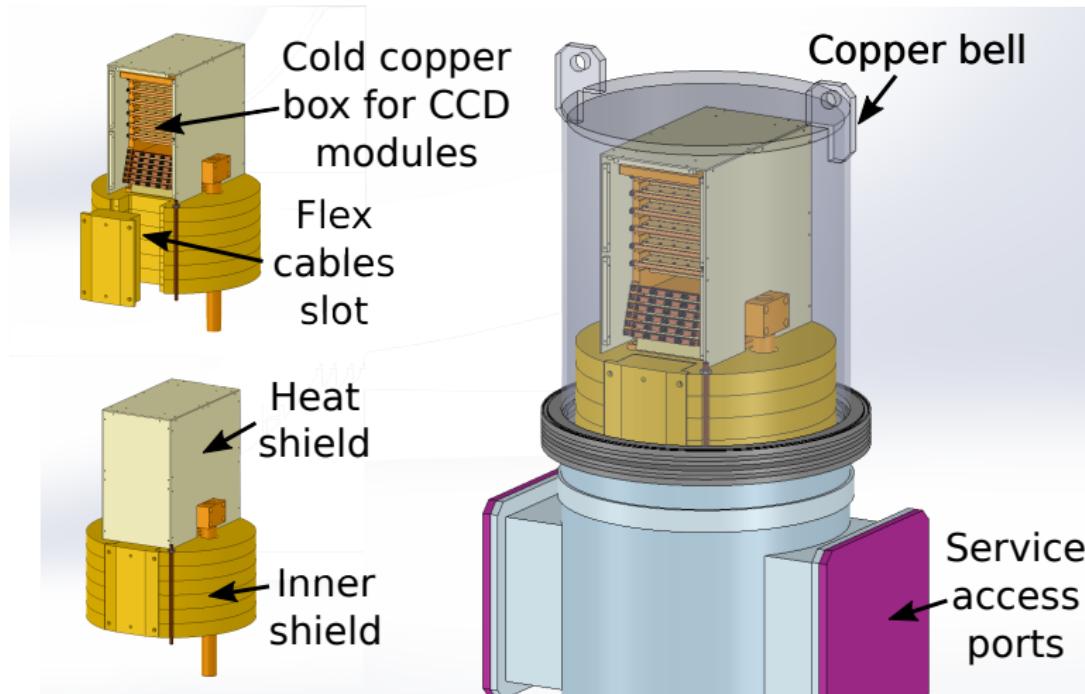


Summary

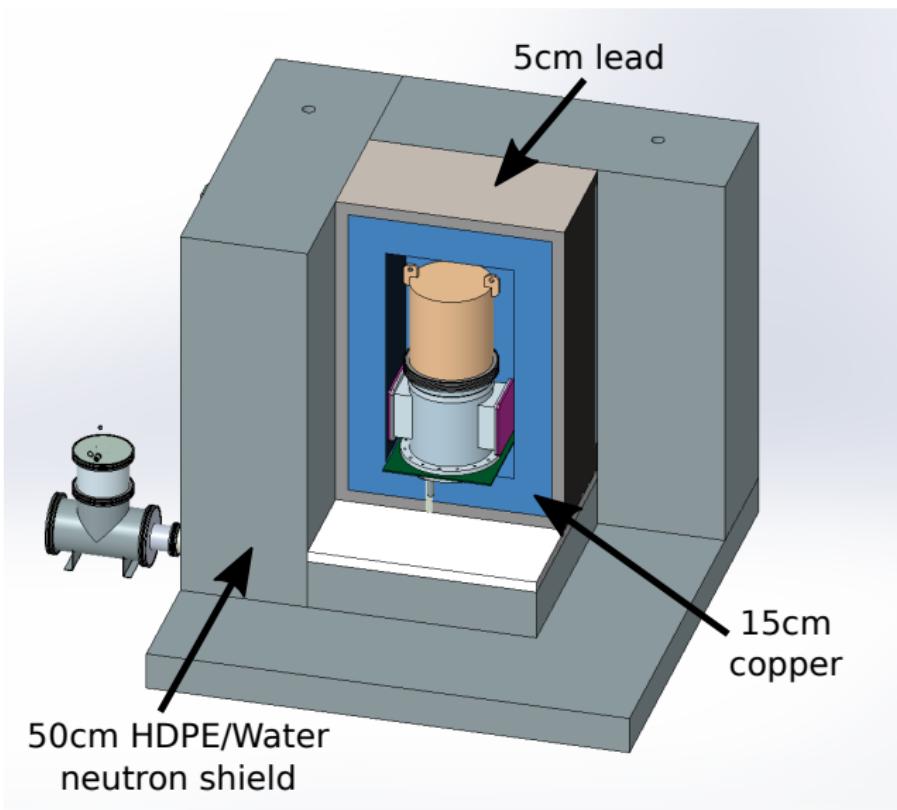
- SENSEI is the first dedicated experiment searching for electron-DM interactions
- protoSENSEI at the surface probed 0.5-4 MeV masses for the first time, and larger xsec than existing direct-detection constraints
- protoSENSEI at MINOS produced best limit for light DM with masses below 5 MeV
- SENSEI experiment will use better sensors & collect almost 2 million times the exposure of this surface run in next ~2-3 years, probing large regions of uncharted territory populated by popular models
- Fully funded: 10g & 100g design done, construction started.
 - ▶ Grant from Heising-Simons Foundation
 - ▶ Full technical support from Fermilab

BACK UP SLIDES

Snolab vacuum vessel design

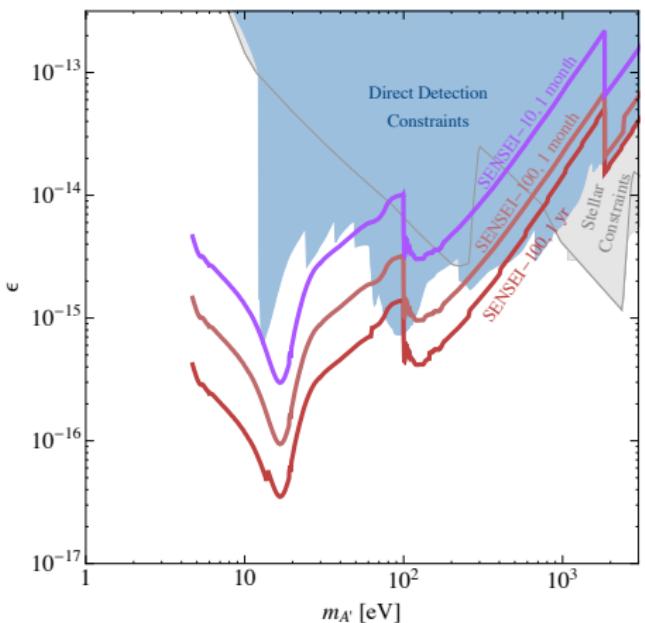


Snolab shield design

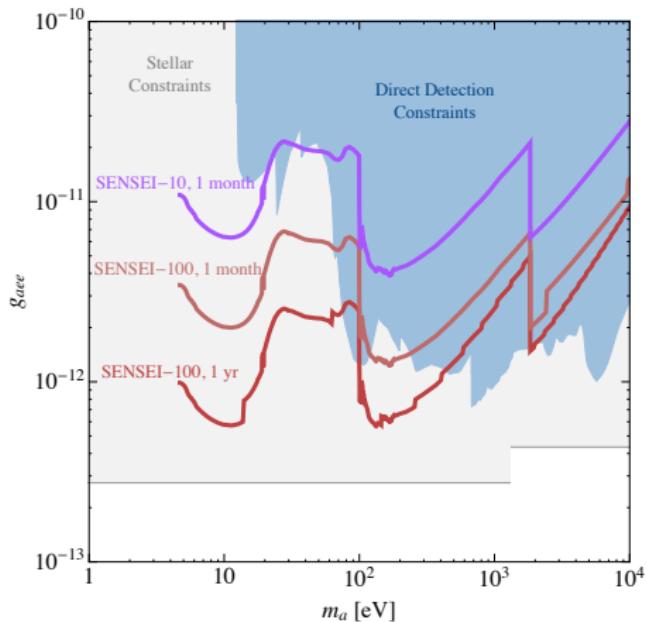


SENSEI: reach of a 100g, zeroish-background experiment

Dark photon (A')



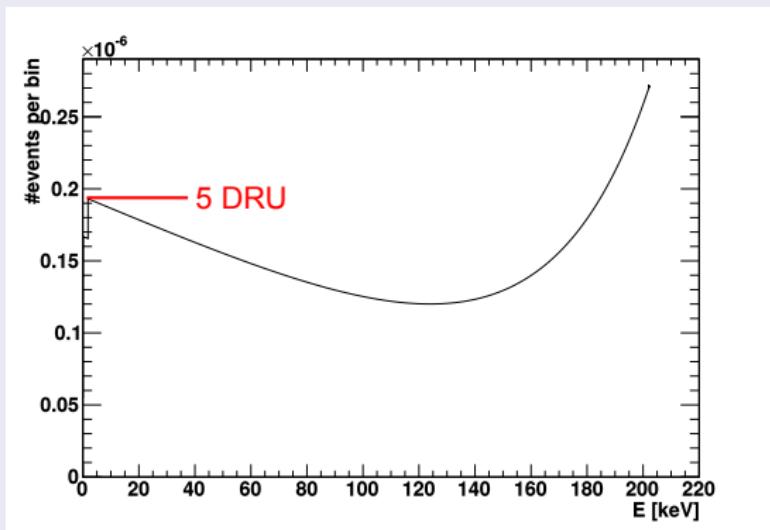
Axion-like-particle (ALP)



SENSEI: electron recoil background requirements

A more detailed analysis: Klein-Nishina + binding energy correction

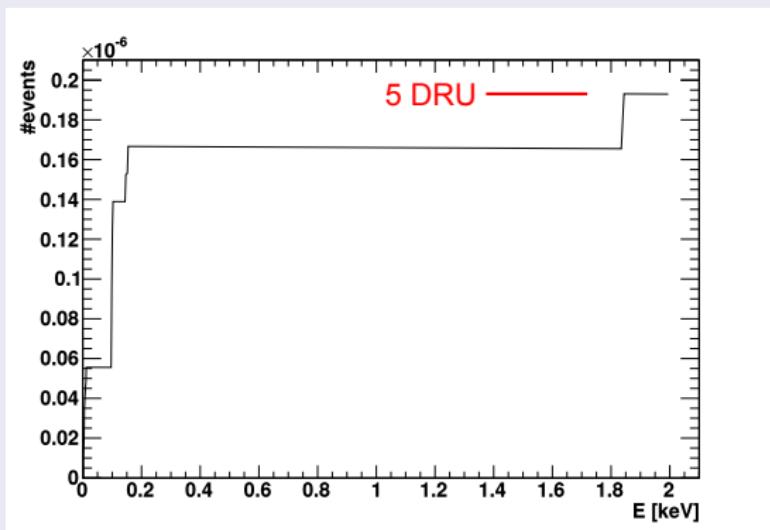
- at lower energies atomic binding energies are relevant
- partial energy depositions populate low E region (thin det)



SENSEI: electron recoil background requirements

A more detailed analysis: Klein-Nishina + binding energy correction

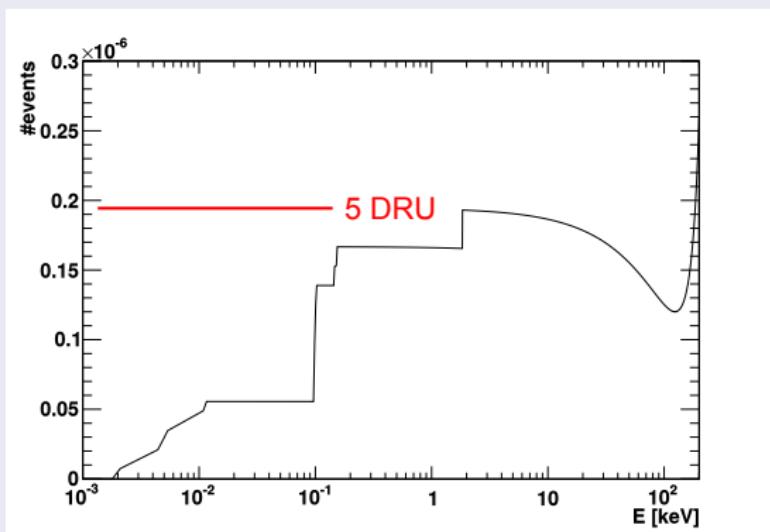
- at lower energies atomic binding energies are relevant
- partial energy depositions populate low E region (thin det)



SENSEI: electron recoil background requirements

A more detailed analysis: Klein-Nishina + binding energy correction

- at lower energies atomic binding energies are relevant
- partial energy depositions populate low E region (thin det)



SENSEI: electron recoil background requirements

A more detailed analysis: MC simulation, G4 3D Monash model

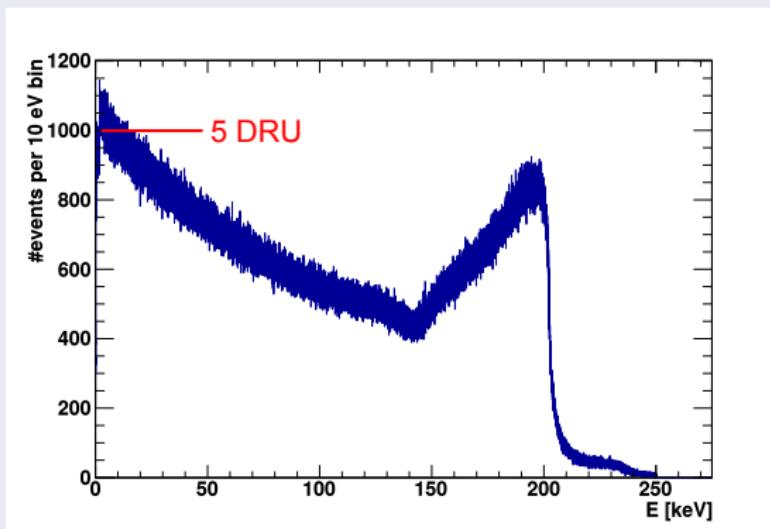
- at lower energies atomic binding energies are relevant
- **partial energy depositions populate low E region (thin det)**



SENSEI: electron recoil background requirements

A more detailed analysis: MC simulation, G4 3D Monash model

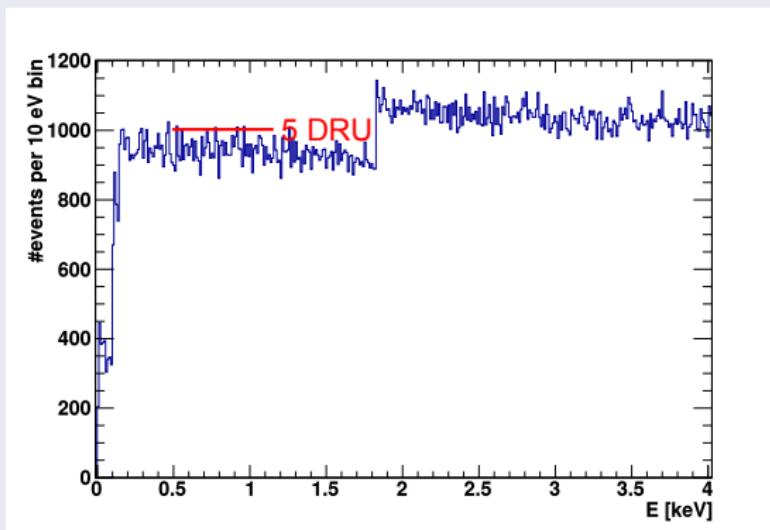
- at lower energies atomic binding energies are relevant
- **partial energy depositions populate low E region (thin det)**



SENSEI: electron recoil background requirements

A more detailed analysis: MC simulation, G4 3D Monash model

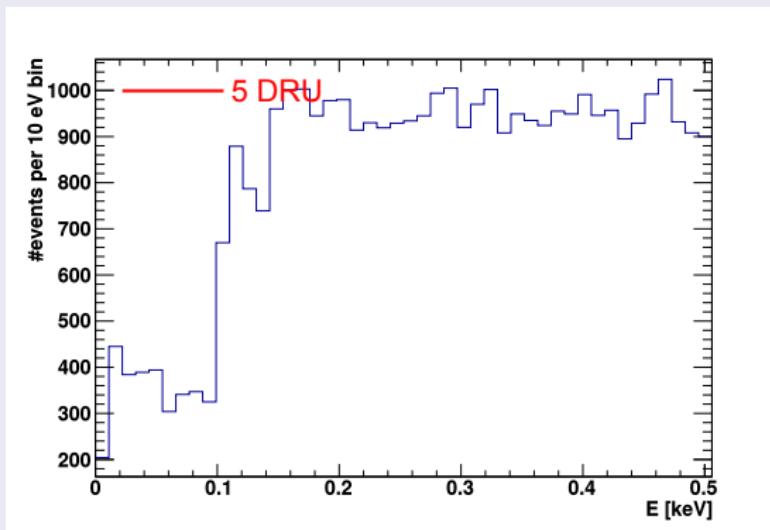
- at lower energies atomic binding energies are relevant
- **partial energy depositions populate low E region (thin det)**



SENSEI: electron recoil background requirements

A more detailed analysis: MC simulation, G4 3D Monash model

- at lower energies atomic binding energies are relevant
- **partial energy depositions populate low E region (thin det)**

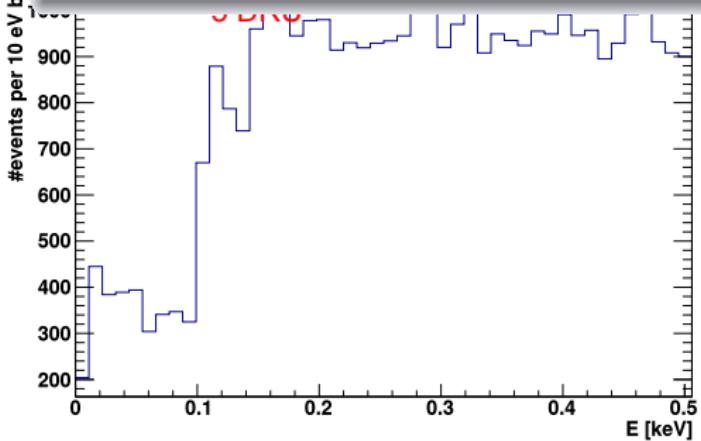


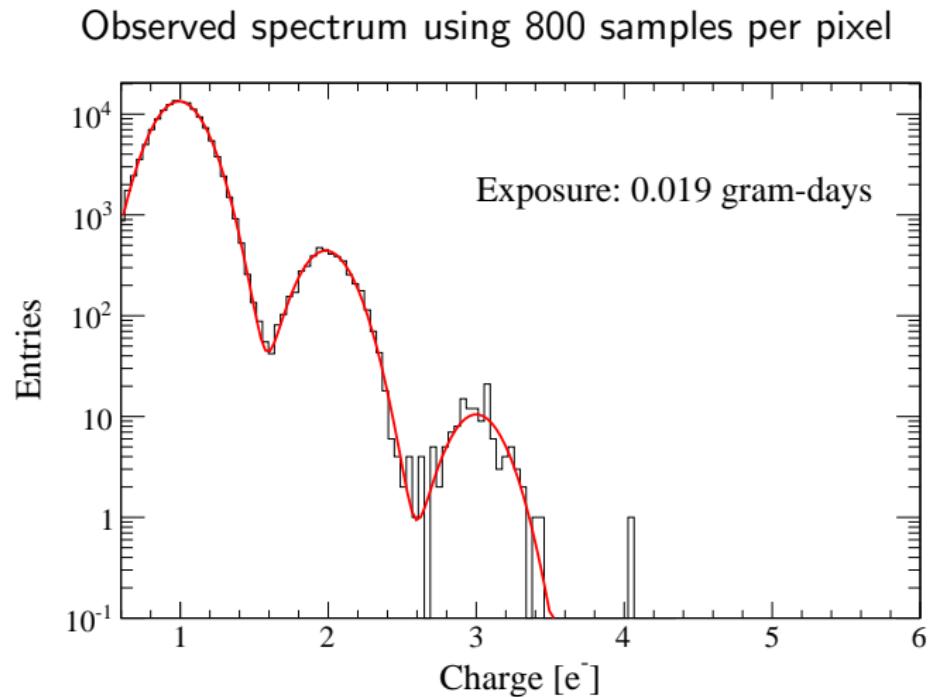
SENSEI: electron recoil background requirements

A more detailed analysis: MC simulation, G4 3D Monash model

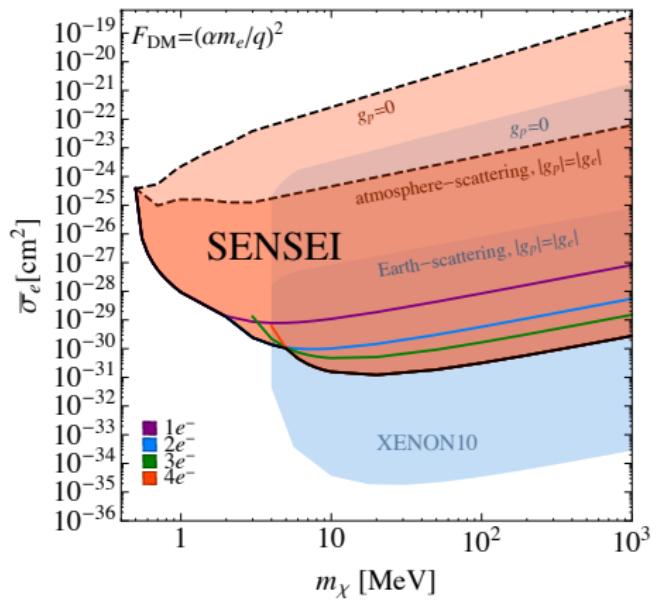
- at lower energies atomic binding energies are relevant
- partial energy depositions populate low E region (thin det)

Back of the envelope
estimation is conservative





dark current: $\sim 1.1 e^- / \text{pix/day}$; no events with 5-100 electrons

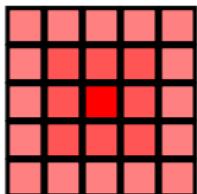
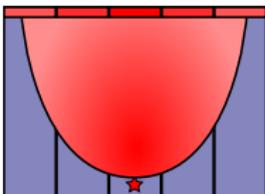
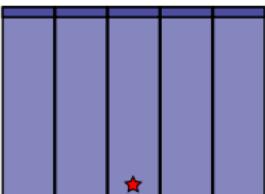
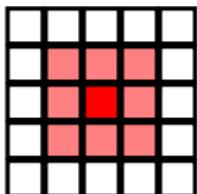
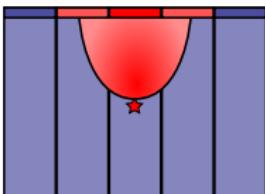
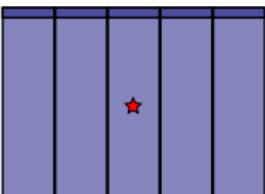
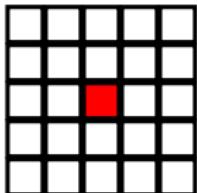
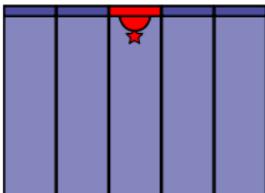
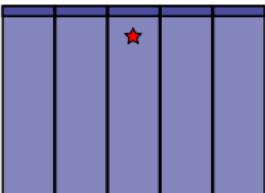
First direct-detection constraints between ~ 500 keV to 4 MeV!

Terrestrial effects: Emken, Essig, Kouvaris, Sholapurkar (to appear)

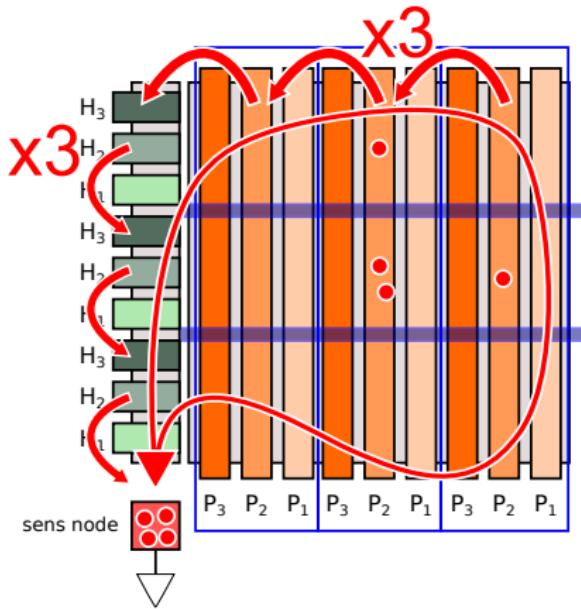
Selection efficiency

$N_{e,\min}$ Cuts	1	2	3	4	5
1. Single pixel	1	0.62	0.48	0.41	0.37
2. Nearest Neighbor	0.8	0.8	0.8	0.8	0.8
3. Noise	0.88	0.88	0.88	0.88	0.88
4. Bleeding	0.95	0.95	0.95	0.95	0.95
Total	0.67	0.41	0.32	0.27	0.24
Number of events	140,302	4,676	131	1	0

Diffusion



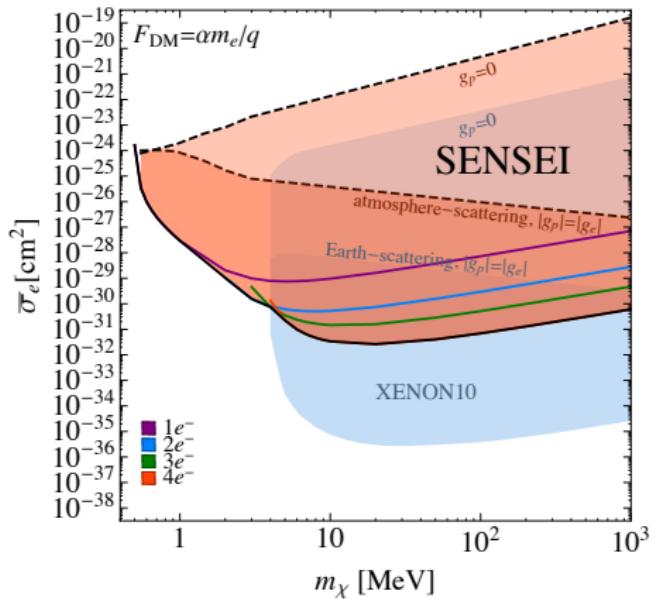
Hardware binning



The optimal effective pixel size can be chosen by using hw binning

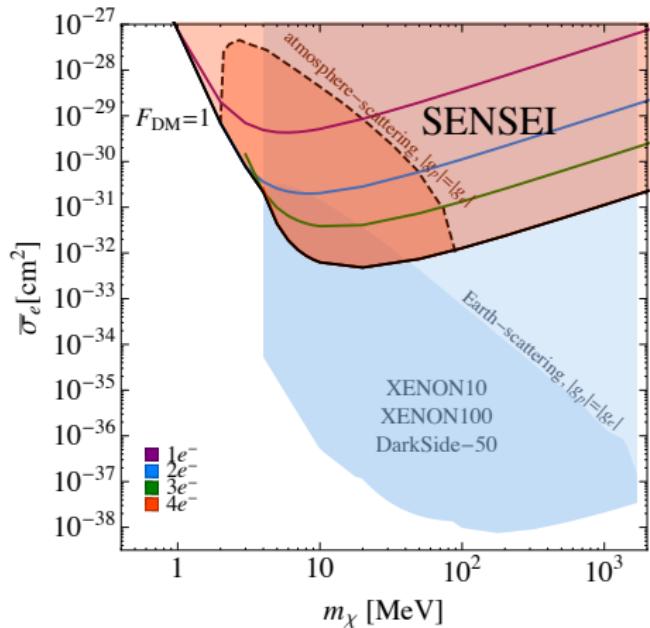
$$\mu_{\text{single}} = R_{\text{DC}} \times \underbrace{(T_{\text{pix}} \times n_{\text{pix}})}_{T_{\text{expo}}} = \mu_{\text{binning}} = \underbrace{(n_{\text{bin}} \times R_{\text{DC}})}_{\text{Eff DC}} \times \underbrace{T_{\text{pix}} \times n_{\text{pix}} / n_{\text{bin}}}_{T_{\text{expo}}}$$

First direct-detection constraints between ~ 500 keV to 4 MeV!



Terrestrial effects: Timon Emken, RE, Kouvaris, Mukul Sholapurkar (to appear)

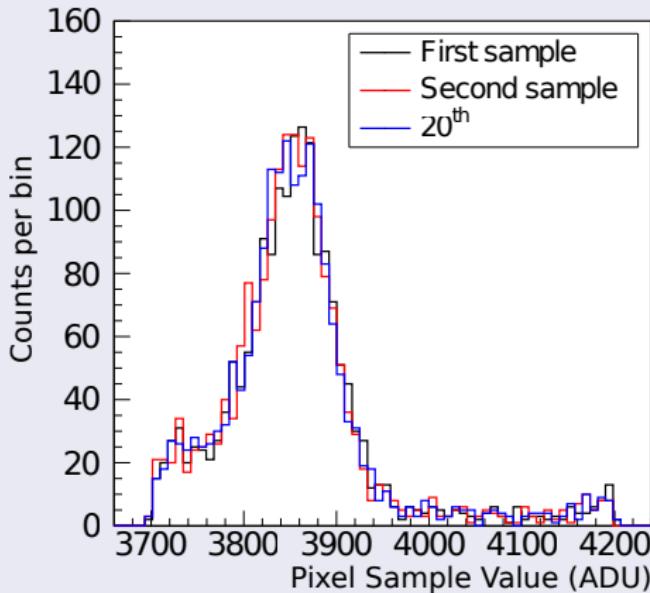
First direct-detection constraints between ~ 500 keV to 4 MeV!



Terrestrial effects: Timon Emken, RE, Kouvaris, Mukul Sholapurkar (to appear)

Image taken with SENSEI: 20 samples per pixel

Single pixel distribution: X-rays from ^{55}Fe



The gain is the same for all the samples